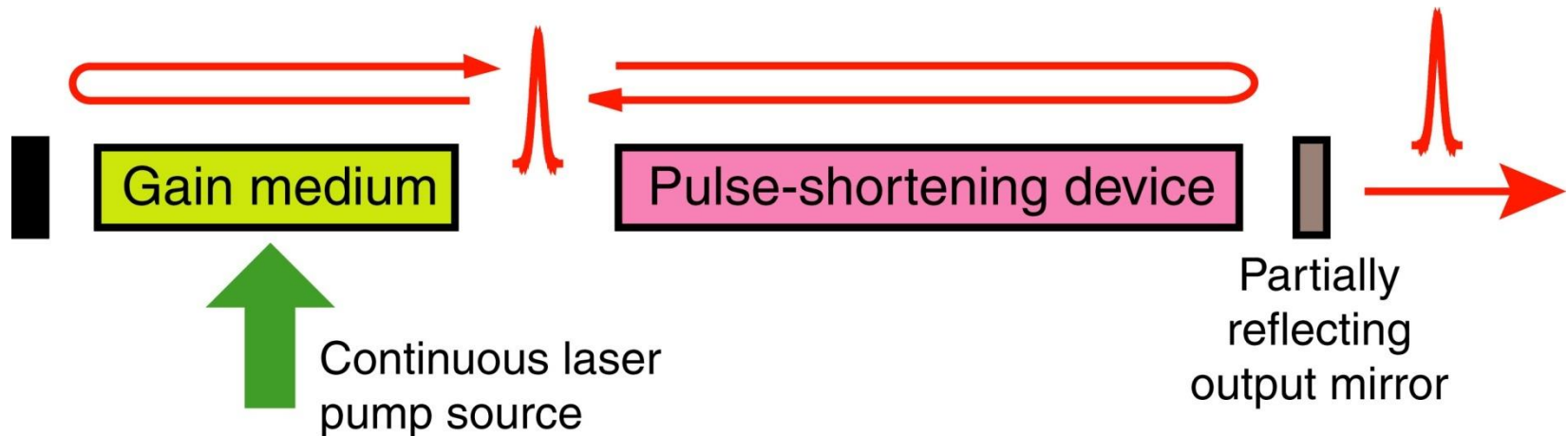


# A generic ultrashort-pulse laser

- A generic ultrafast laser has a broadband gain medium, a pulse-shortening device, and two or more mirrors:

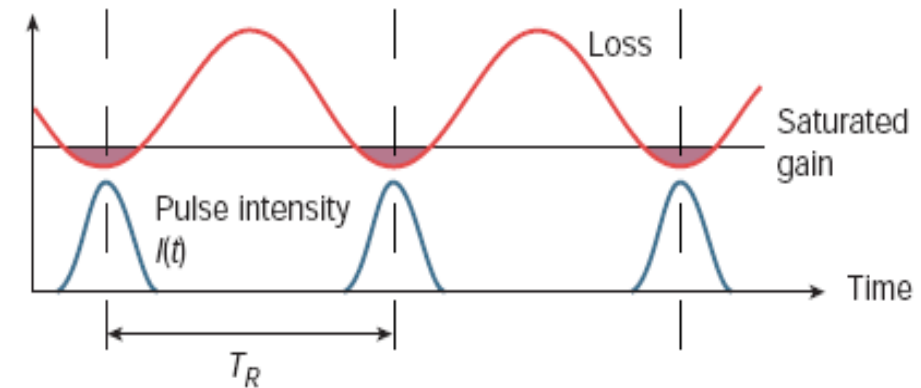


Many pulse-shortening devices have been proposed and used.

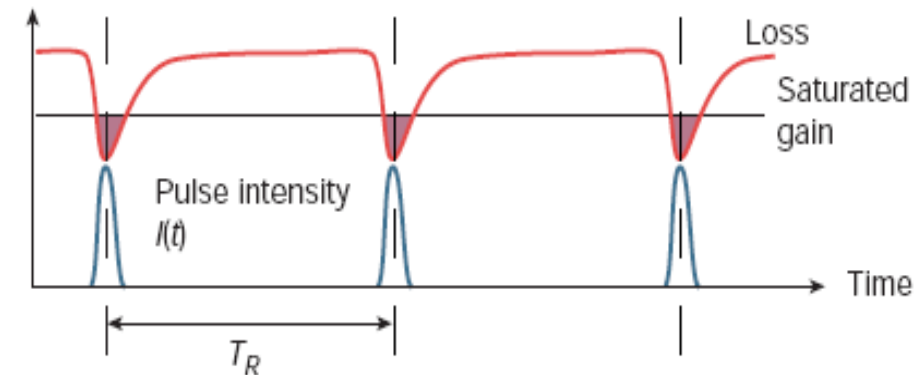
# Active and Passive Mode Locking

- The **acoustic-optical** or **electro-optical modulator**  $\Rightarrow$  periodic sinusoidal loss modulation  $\Rightarrow$  equal the **cavity round trip time**
- A saturable absorber  $\Rightarrow$  to obtain a **self-amplitude modulation** of the light inside the laser cavity.
- **Loss modulation**  $\Rightarrow$  Relatively large for **low intensities** but significantly smaller for a short pulse with high intensity.
- The **high intensity** @ the peak of pulse  $\Rightarrow$  saturates the absorber more strongly than its low intensity wings  $\Rightarrow$  **pulse shaping effect**

Active modelocking

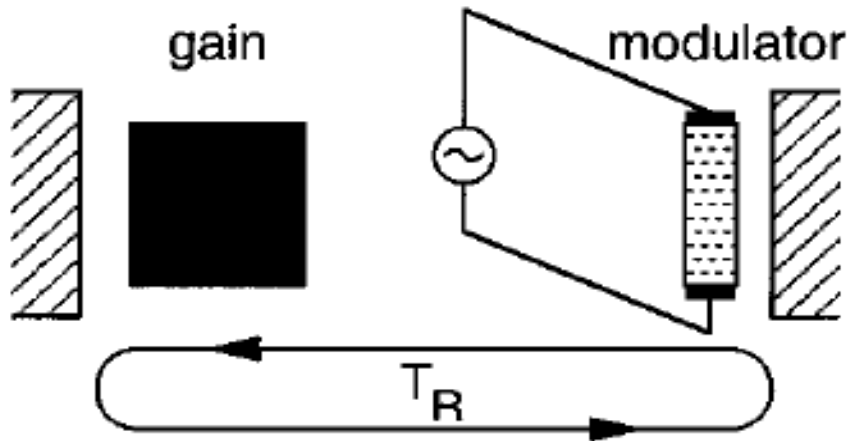


Passive modelocking



# Active mode-locking

- Any amplitude modulator can preferentially induce losses for times other than that of the intended pulse peak. This produces short pulses.
- It can be used to start a Ti:Sapphire laser mode-locking.



Schematic of actively mode-locked laser

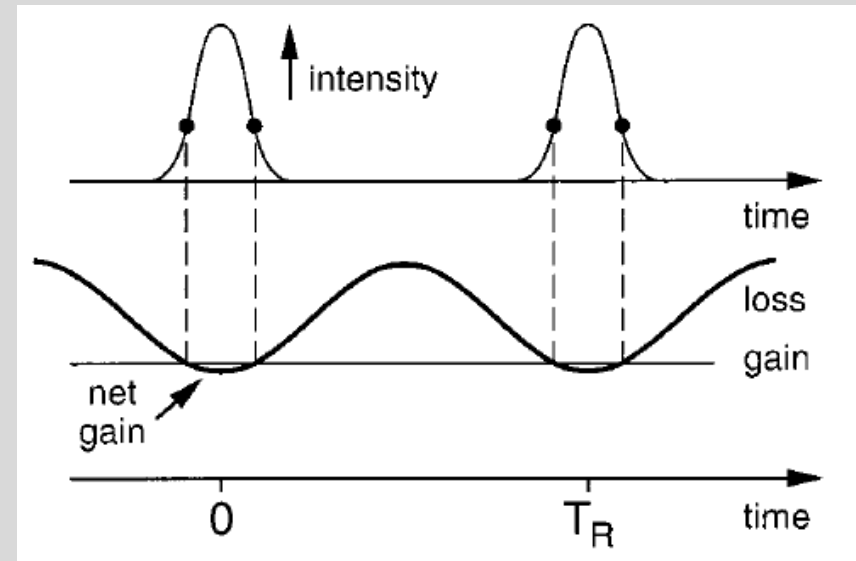
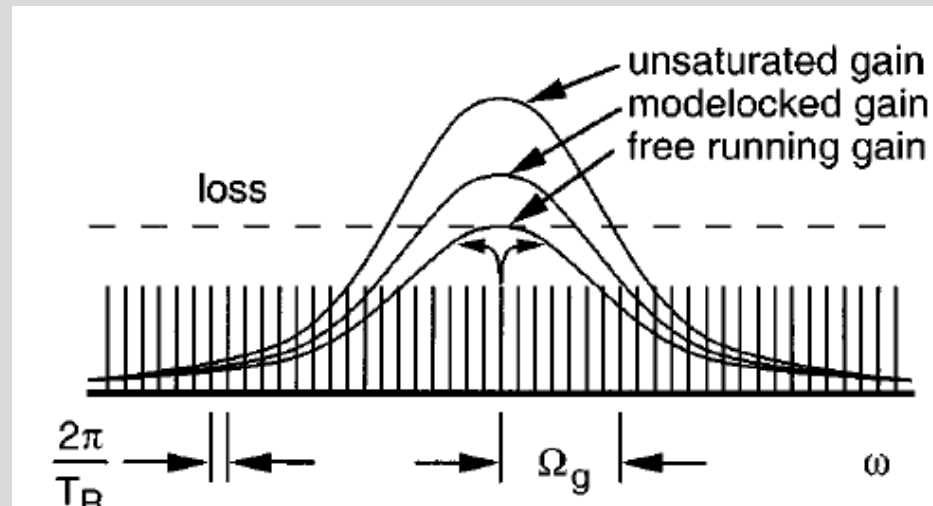
# Schematic of actively mode-locked laser, the spectrum in the time domain and the time dependence of net gain.

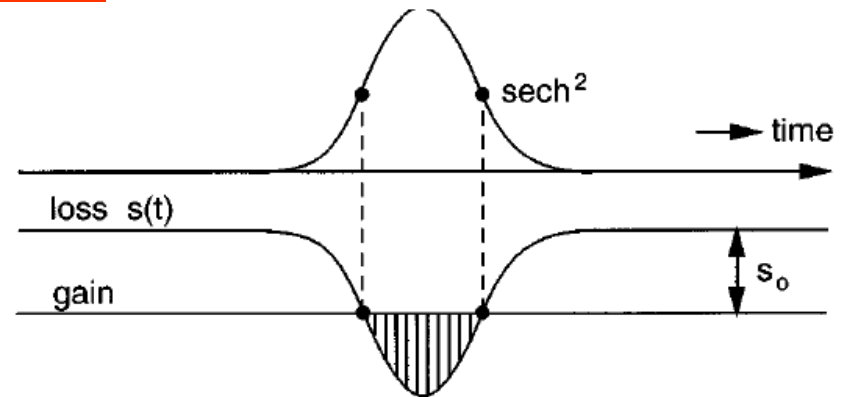
- An optical Fabry–Pérot resonator formed of two mirrors has axial modes separated in frequency by

$$\Delta\Omega = 2\pi/T_R$$

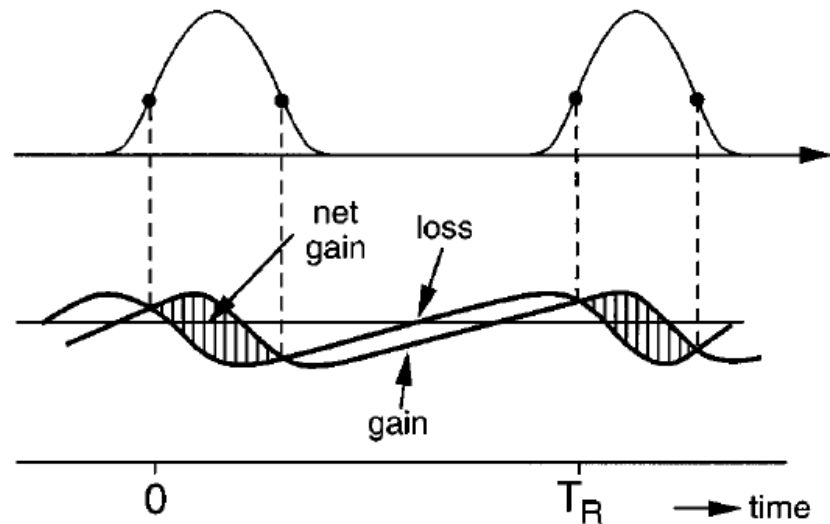
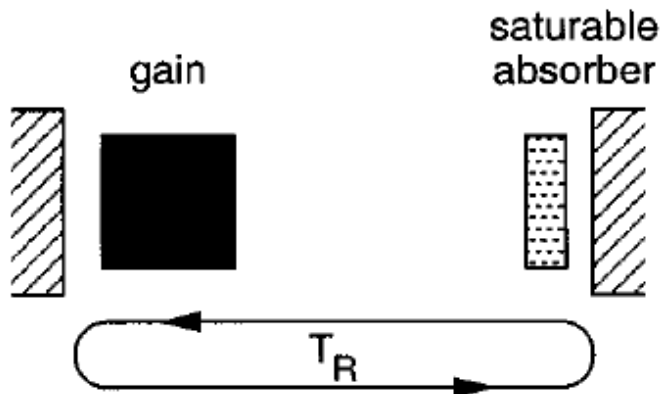
Where  $T_R$  is the roundtrip time.

Active mode-locking does not lead to ultrashort pulses



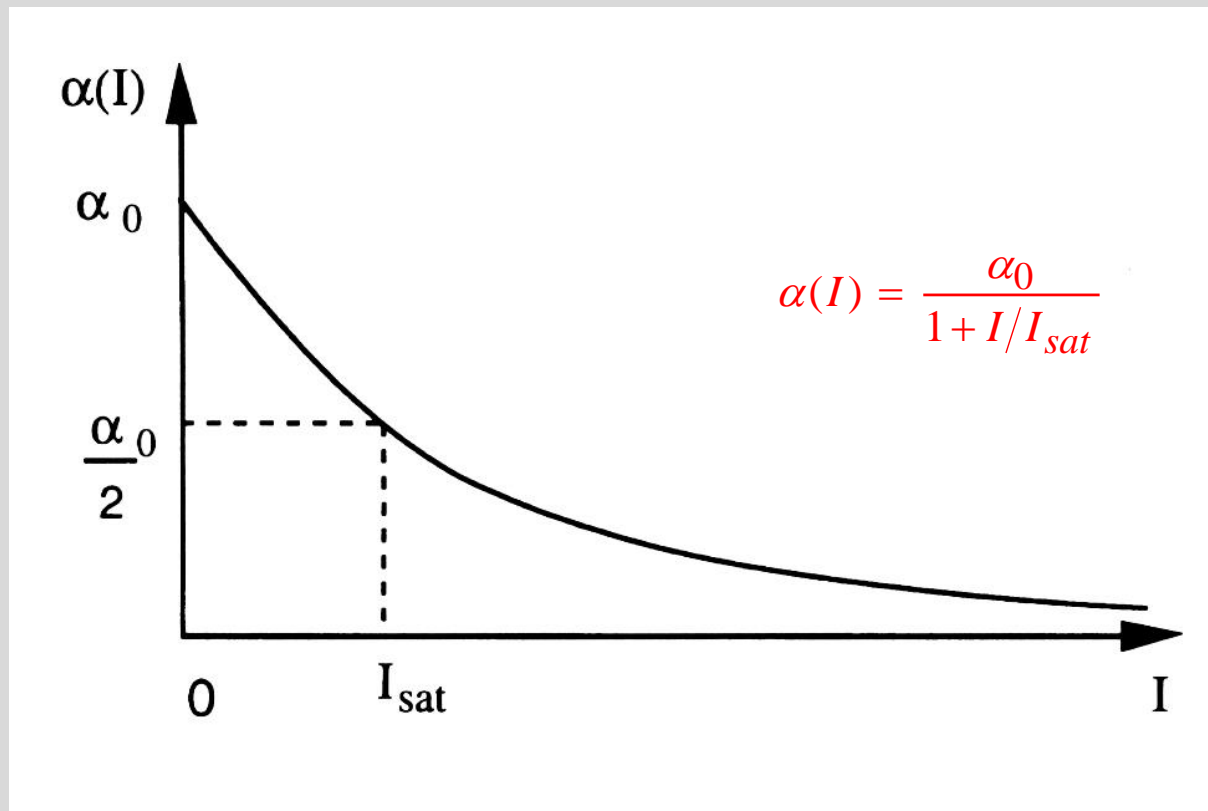


Schematic of laser passively mode-locked with fast saturable absorber and the time dependence of pulse, and net gain



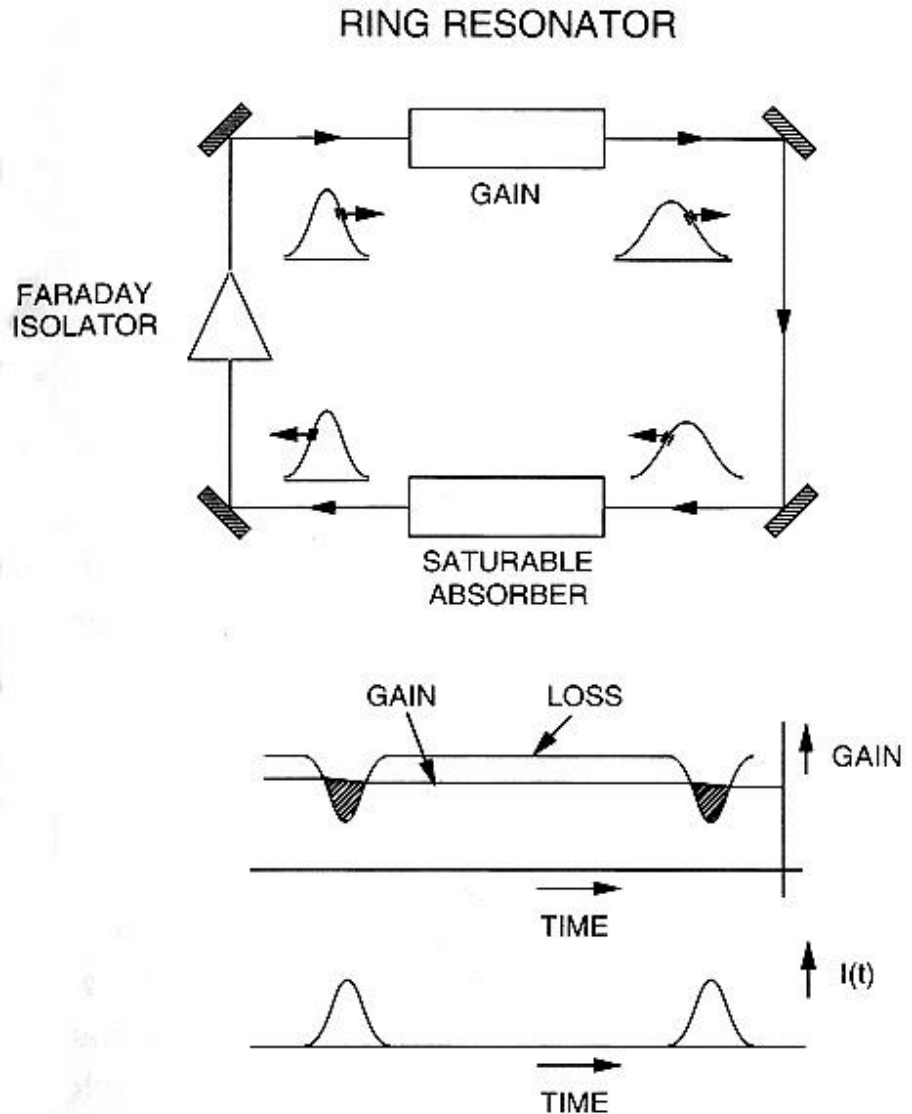
# Passive mode-locking: the saturable absorber

- Like a sponge, an absorbing medium can only absorb so much.
- High-intensity spikes burn through; low-intensity light is absorbed.



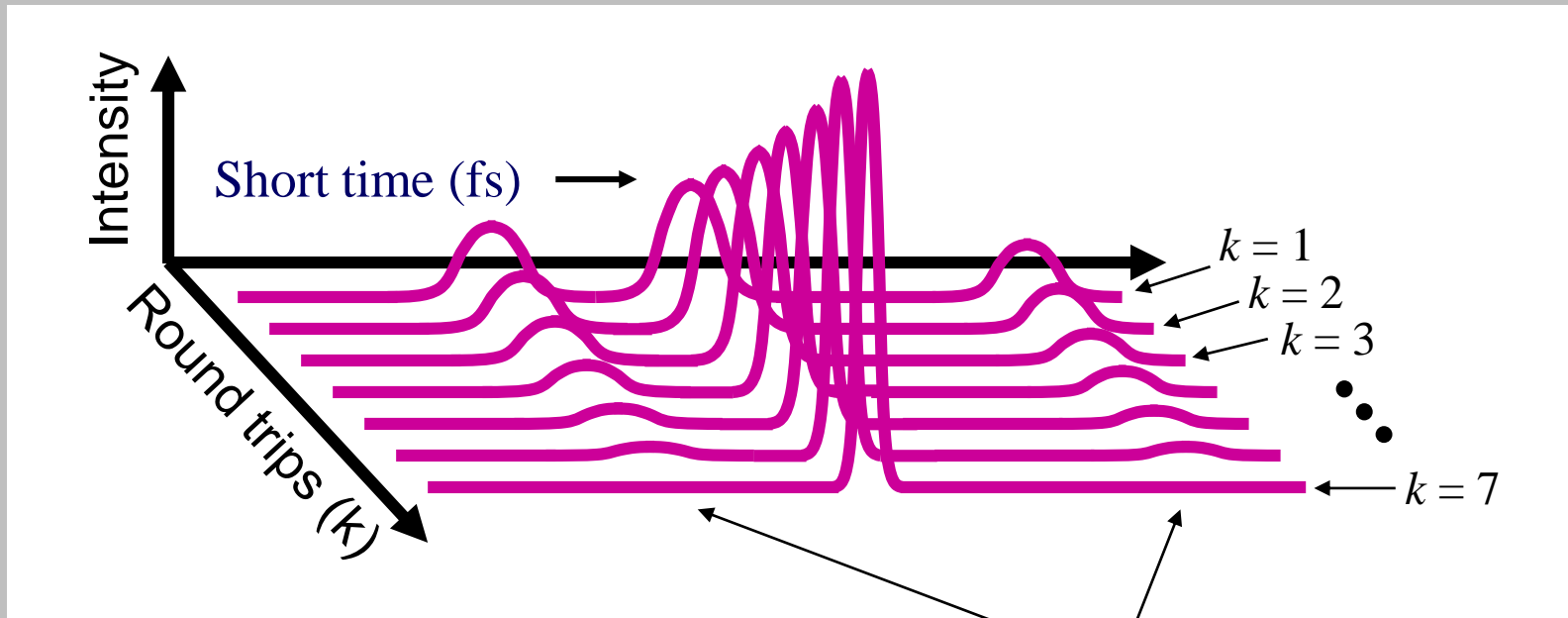
# Passive mode-locking: the saturable absorber

- High-intensity spikes (i.e., short pulses) see less loss and hence can lase while low-intensity backgrounds (i.e., long pulses) won't.



# The effect of a saturable absorber

First, imagine raster-scanning the pulse vs. time like this:



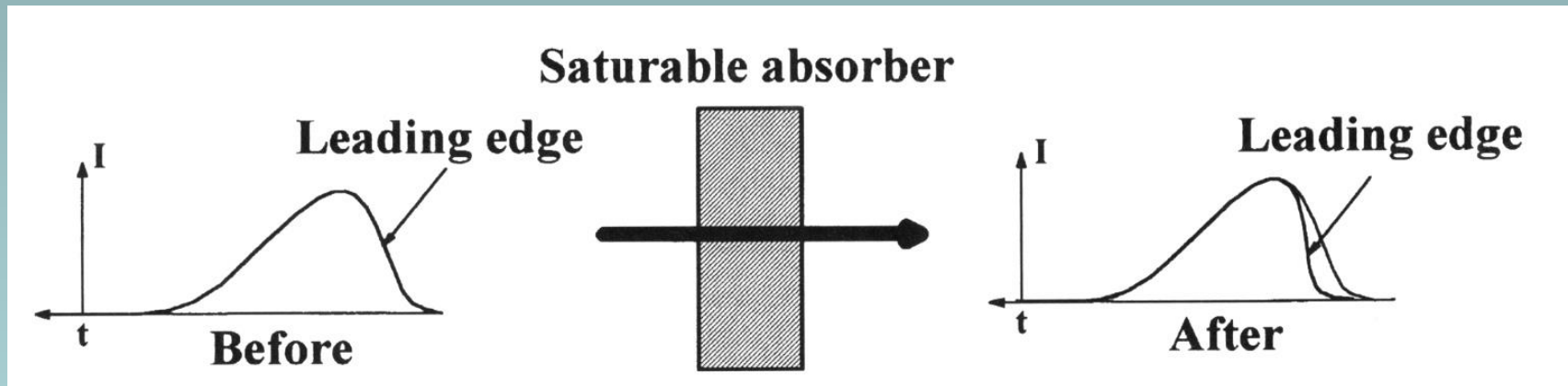
Notice that the weak pulses are suppressed, and the strong pulse shortens and is amplified.

After many round trips, even a slightly saturable absorber can yield a very short pulse.



# Passive Mode-locking with a Slow Saturable Absorber

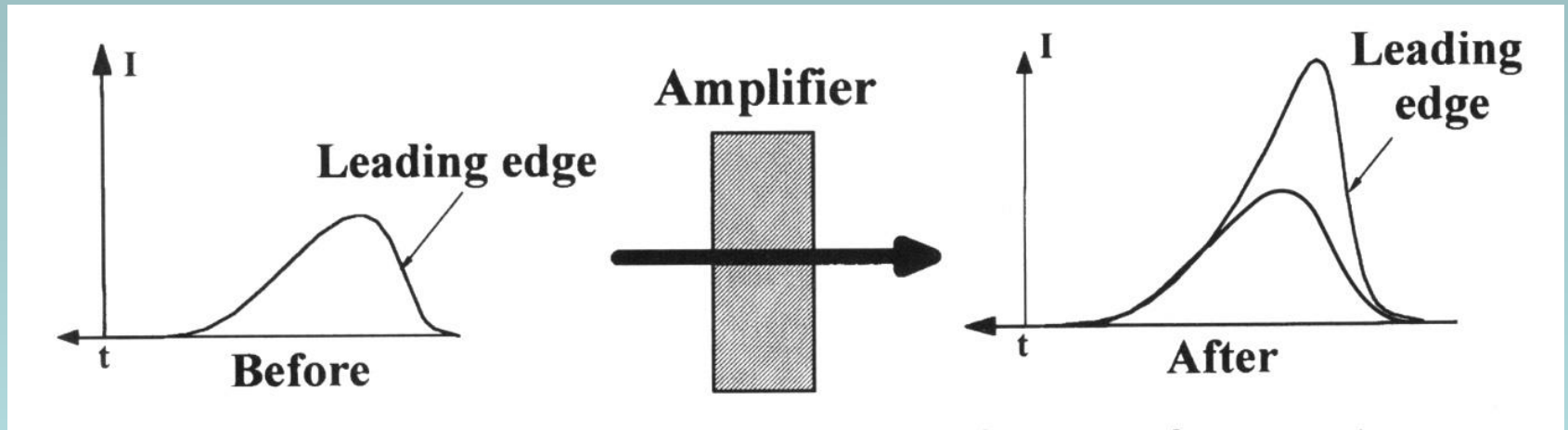
- What if the **absorber** responds **slowly** (more slowly than the pulse)?
- Then only the **leading edge** will experience pulse shortening.



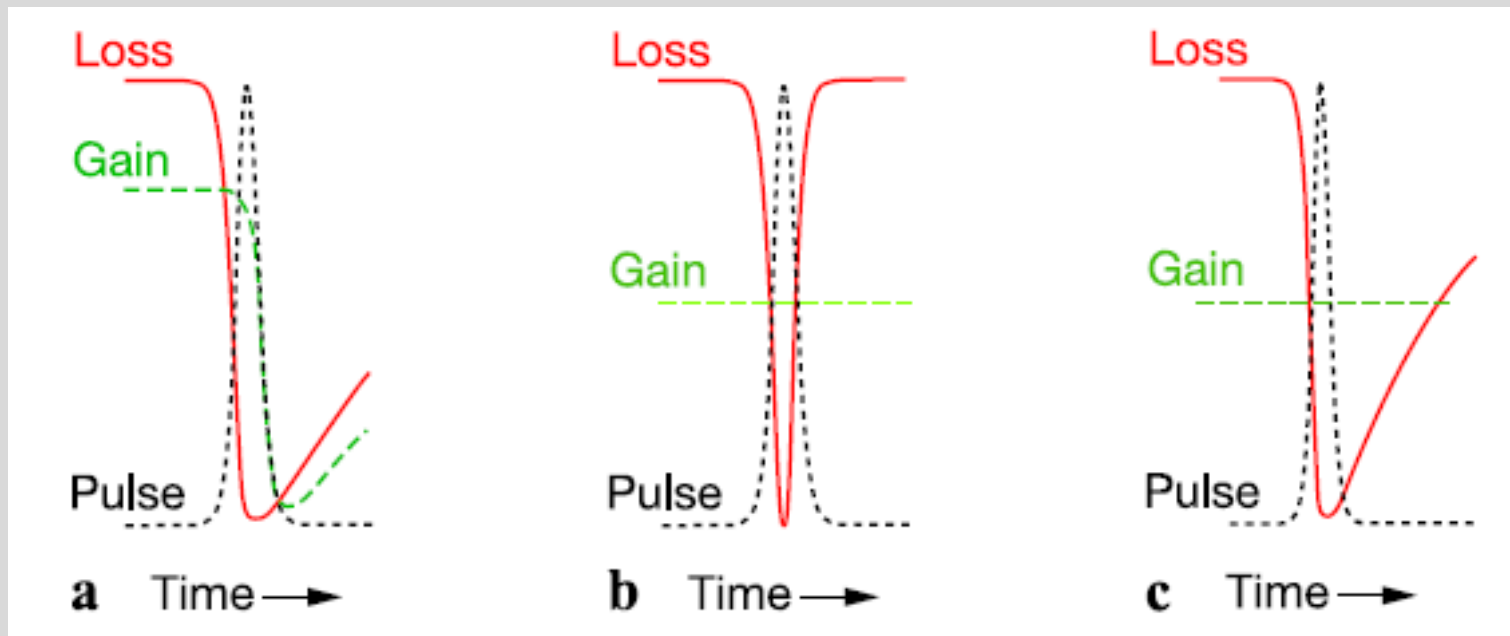
This is the most common situation, unless the pulse is many ps long.

# Gain Saturation shortens the pulse trailing edge.

- The **intense spike** uses up the **laser gain-medium energy**, reducing the **gain available** for the **trailing edge** of the pulse (and for later pulses).



# Summary of the different mode locking techniques:

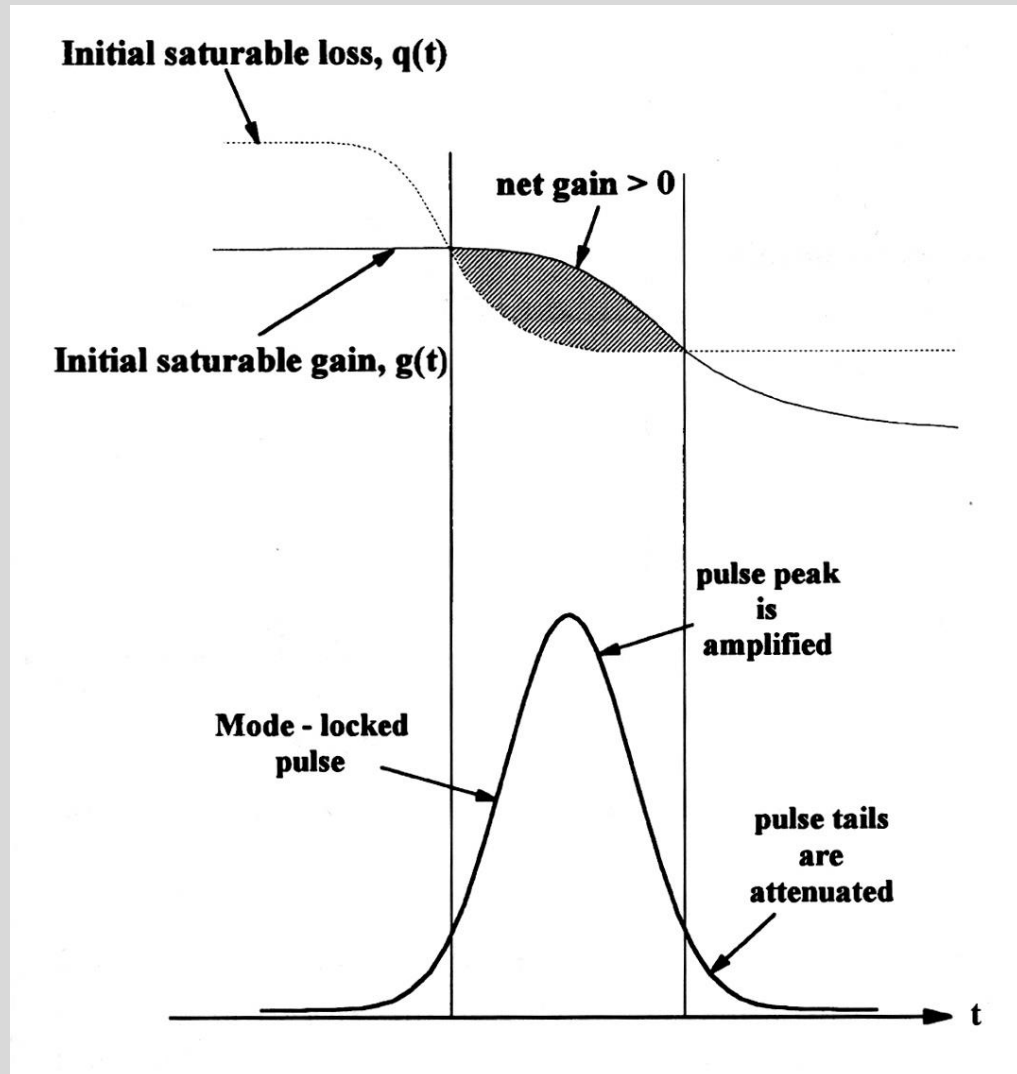


- (a) **Passive mode-locking with a slow saturable absorber and dynamic gain saturation**
- (b) **Passive mode-locking with a fast saturable absorber**
- (c) **Passive mode-locking with a slow saturable absorber without dynamic gain saturation in the picosecond regime and in the femtosecond regime (referred to as soliton mode-locking)**

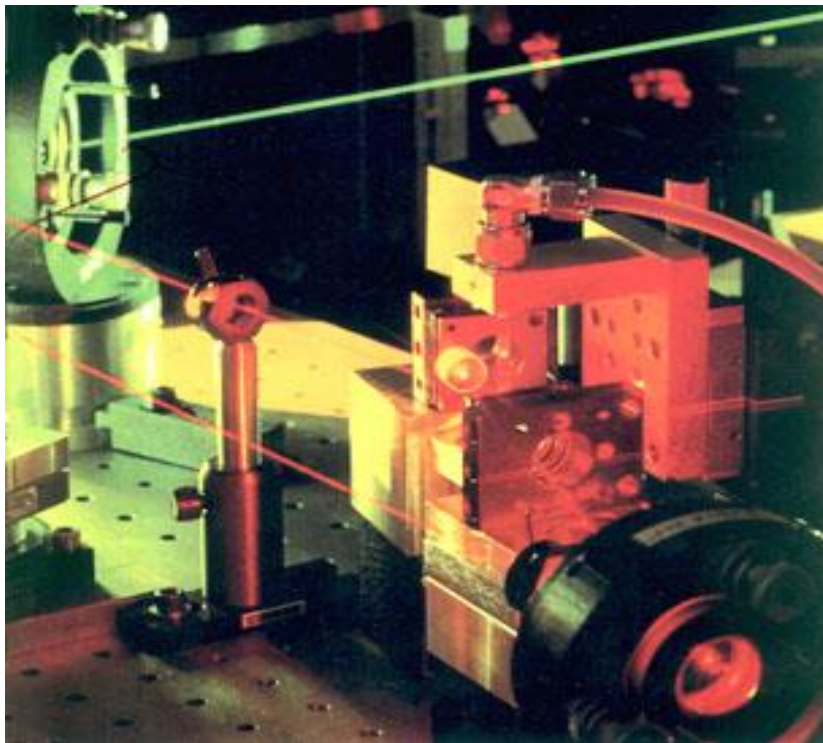
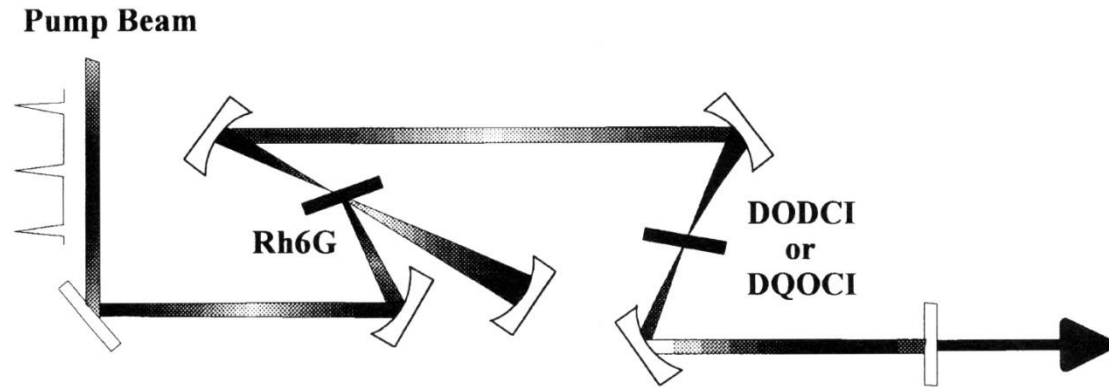
# Saturable gain and loss

Lasers lase when the **gain** exceeds the **loss**.

The combination of **saturable absorption** and **saturable gain** yields short pulses even when the **absorber** is **slower** than the pulse.



# The Passively Mode-locked Dye Laser

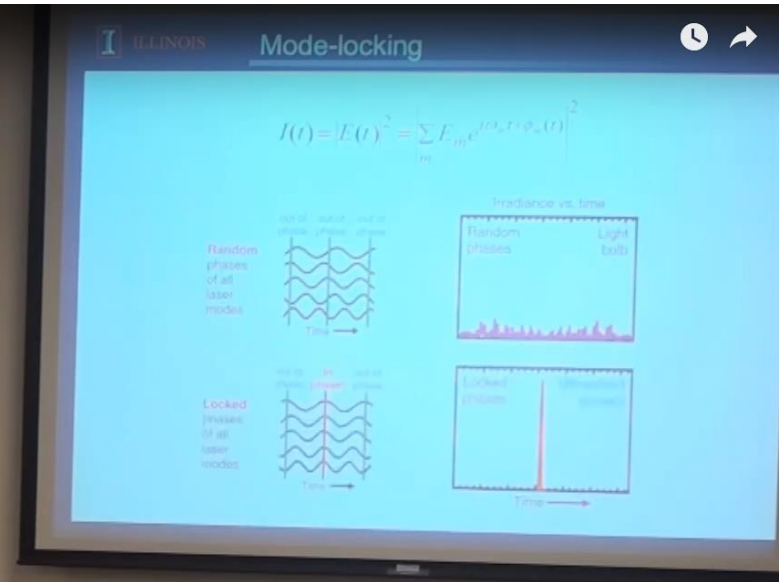
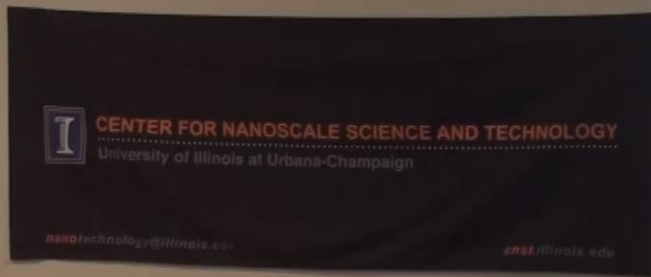


Passively mode-locked dye lasers yield pulses as short as a few hundred fs.

# Mode locking by the saturable absorber

➤ [https://www.youtube.com/watch?v=CVVDnx\\_EhhU](https://www.youtube.com/watch?v=CVVDnx_EhhU)

Improving the Pulse Stability of Mode-Locked Diode Lasers



3:29 / 21:18

## Some common dyes and their corresponding saturable absorbers

Gain dye	Saturable absorber	Wavelength in nm
Rh6G	DODCI, DDI	575–620
Kiton Red	DQOCI	600–655
DCM	DODCI, DTDCI	620–660
Pyridine 1	DTDCI, DDI	670–740
LD 700	DTDCI, DDI, IR 140	700–800
Pyridine 2	IR 140, HITC	690–770
Styryl 9M	DDI, IR 140	780–860



# Passive mode locked fiber lasers in use of saturable absorber

## Saturable absorber (SA)

## Disadvantage

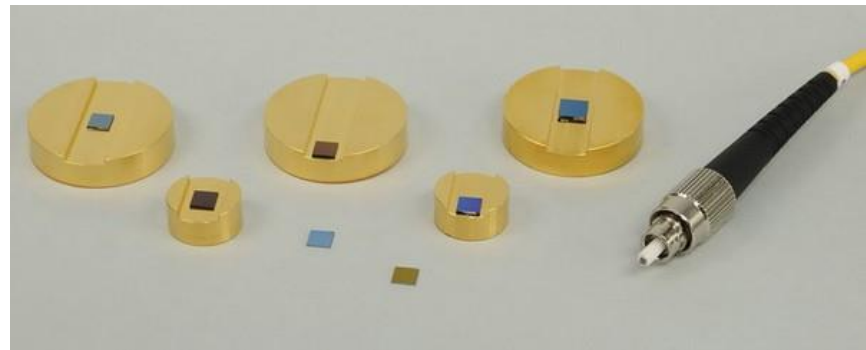
Semiconductor saturable absorber mirror (SESAM)

[1]

1. Complicated fabrication and packaging technique  
2. Limited operation bandwidth

Bottom reflector

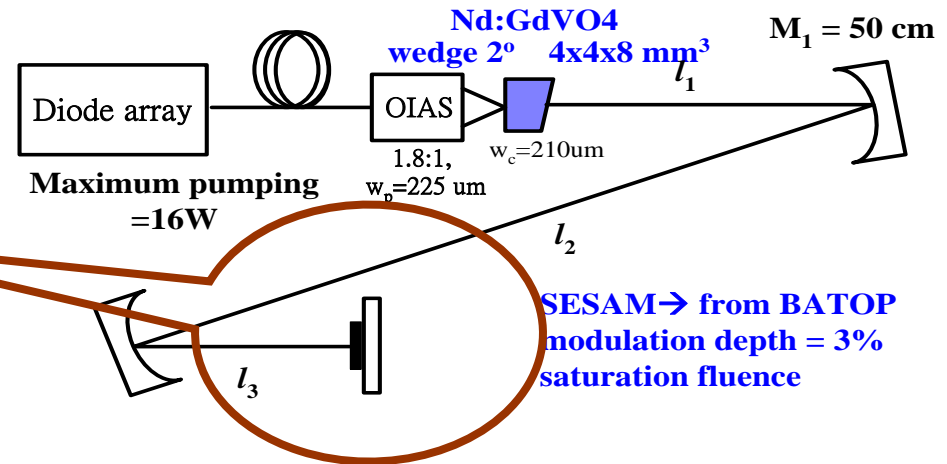
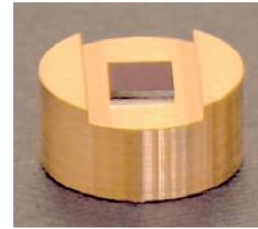
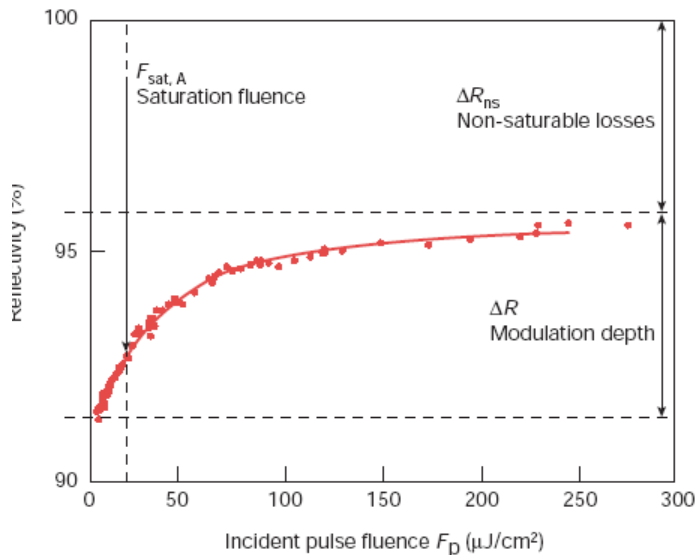
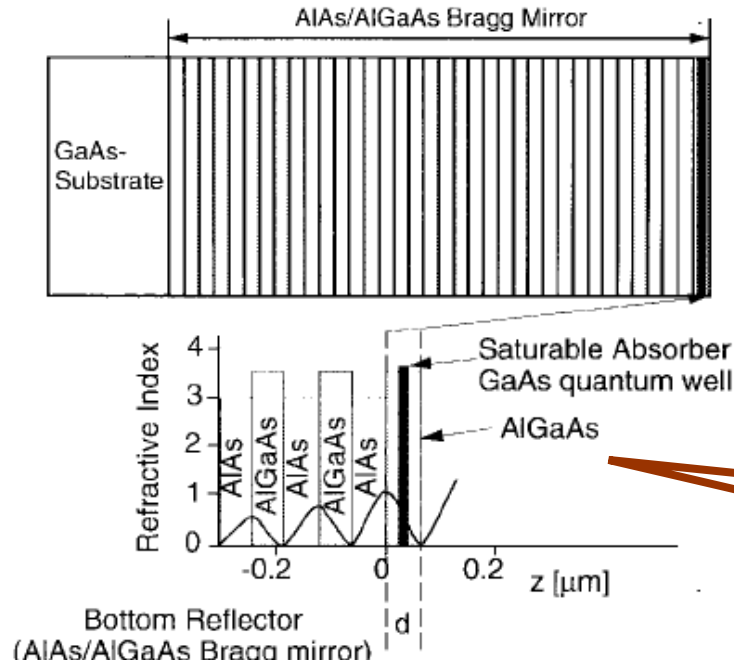
Top reflector



➤ SAs demand less stringent fabrication method, fast recovery time, low saturation intensity and low cost.

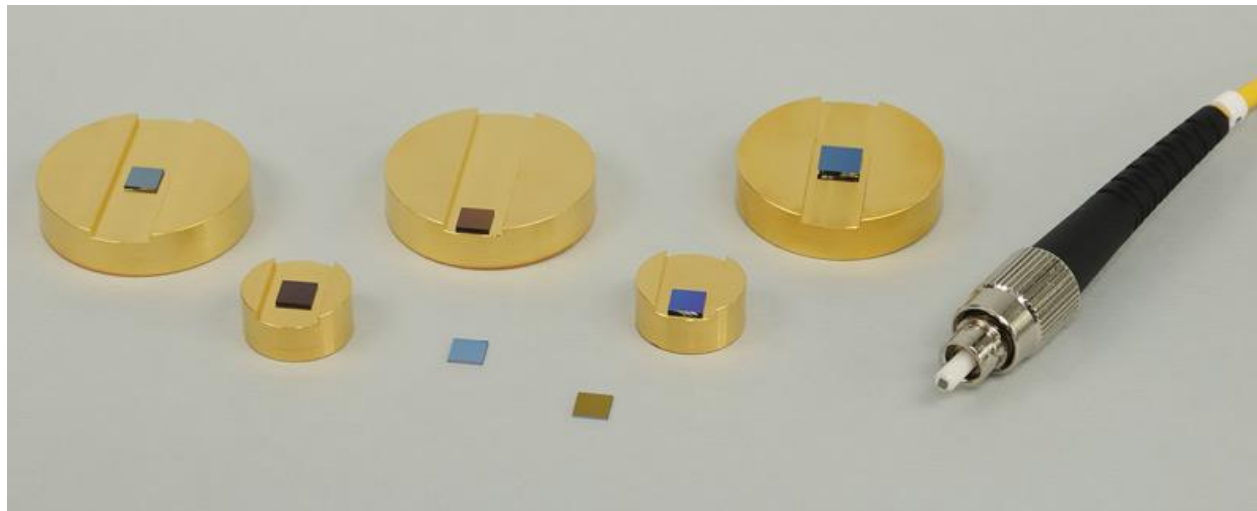
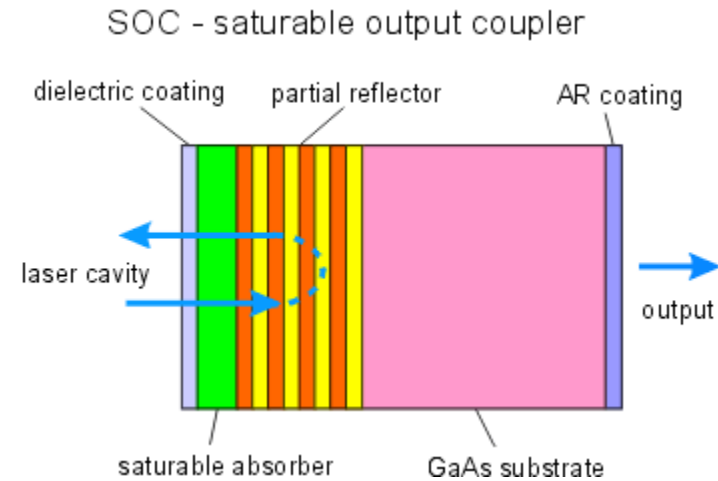
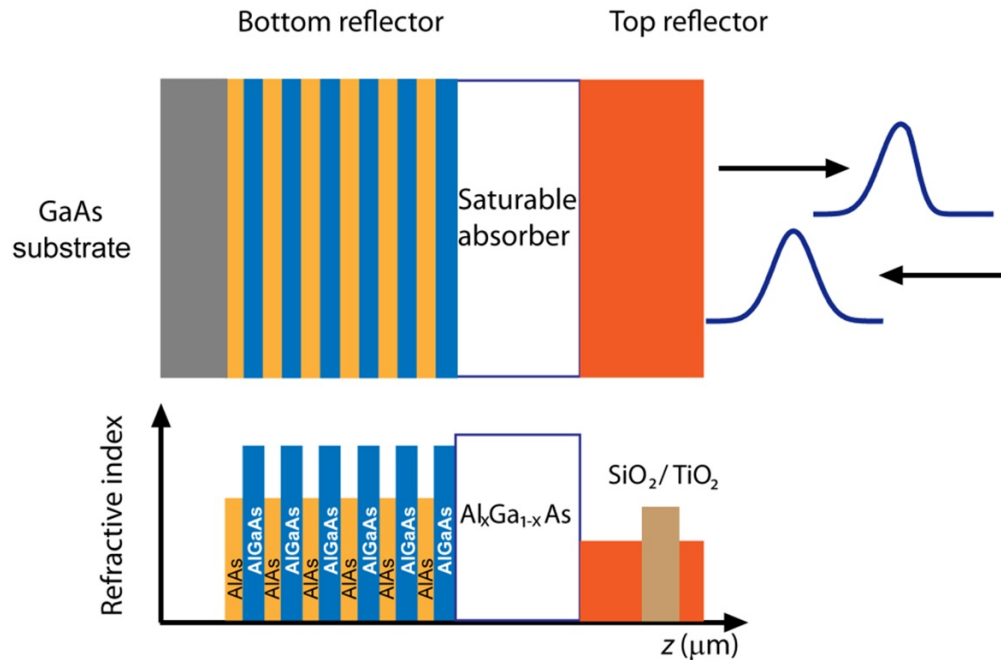


# Semiconductor Saturable Mirror (SESAM)



- A saturable absorber in conjunction with the **Bragg mirror** that is formed by the quarter-wave layer of two dielectric media
- **Reflectivity** of the mirror increase @ the peak of the pulse

# Semiconductor saturable absorber mirror



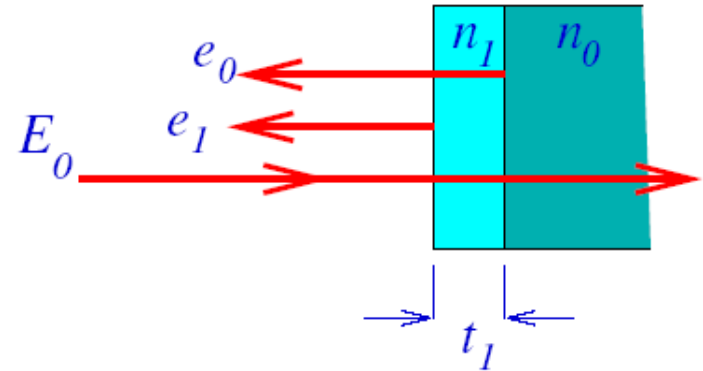
# Single layer Anti-reflection Coating

- At **normal incidence**, the amplitude reflectance of the interface interface between dielectric materials of refractive index  $n_1$  and  $n_2$ ,

$$r = \frac{n_1 - n_2}{n_1 + n_2}$$

- The **intensity reflectance** is

$$R = \left( \frac{n_1 - n_2}{n_1 + n_2} \right)^2$$



- For an air/glass interface with  $n_1 = 1.0$  and  $n_2 = 1.5$ , we get  $R \approx 4\%$ , which is a very significant loss.
- If we illuminate the surface with a normal incident beam of amplitude  $E_0$  and wavelength  $\lambda$ , Then we will get reflections from both the **air/ $n_1$**  and the  **$n_1/n_0$**  interface of  $e_1$  and  $e_0$ ,

$$e_1 = E_0 r_1 \quad \text{and} \quad e_0 = E_0 r_0 \exp(-i g_1)$$

➤ Where

$$r_1 = \frac{1 - n_1}{1 + n_1} \quad \text{and} \quad r_0 = \frac{n_1 - n_0}{n_1 + n_0} \quad \text{and} \quad g_1 = 2 \frac{2\pi}{\lambda} t_1 n_1$$

➤ To get **anti-reflection condition**, we want  $e_1$  and  $e_0$  to cancel, so

$$e_1 + e_0 = 0$$

➤ We want  $e_1$  and  $e_0$  be of opposite sign, so  $g_1 = \pi$ , giving that

$$n_1 t_1 = \frac{\lambda}{4} \quad \text{so that} \quad t_1 = \frac{\lambda}{4n_1}$$

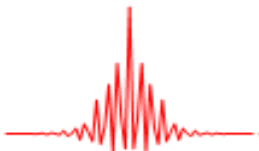
$$g_1 = (2m + 1)\pi \Rightarrow t_1 = (2m + 1) \frac{\lambda}{4n_1}$$

➤ The coating must have a optical path-length of quarter of a wavelength, and also we must have that

$$r_1 = r_0 \quad \text{to that} \quad \frac{1 - n_1}{1 + n_1} = \frac{n_1 - n_0}{n_1 + n_0}$$

➤ It has the solution

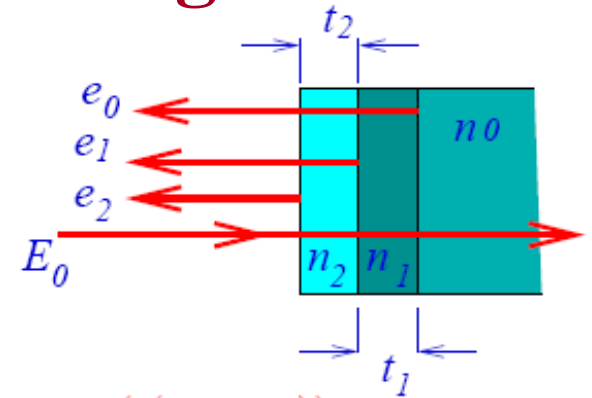
$$n_1 = \sqrt{n_0}$$



# Double layer Anti-reflection Coating

The solution is to use *two* layers coating.

Ignoring multiple reflections, we then want  $e_2 + e_1 + e_0 = 0$



where  $e_2 = E_0 r_2$  and  $e_1 = E_0 r_1 \exp(i g_2)$  and  $e_0 = E_0 r_0 \exp(i(g_2 + g_1))$

Simplest case *quarter wave*,  $g_1 = g_2 = \pi$ , so,

$$t_2 = \frac{\lambda}{4n_2} \quad \text{and} \quad t_1 = \frac{\lambda}{4n_1}$$

For an *anti-reflection* coating we require that

$$r_2 - r_1 + r_0 = 0$$

where we have that  $r_2 = \frac{1 - n_2}{1 + n_2}$  and  $r_1 = \frac{n_2 - n_1}{n_2 + n_1}$  and  $r_0 = \frac{n_1 - n_0}{n_1 + n_0}$

which if *you* expand, and collect terms, give the required solution that

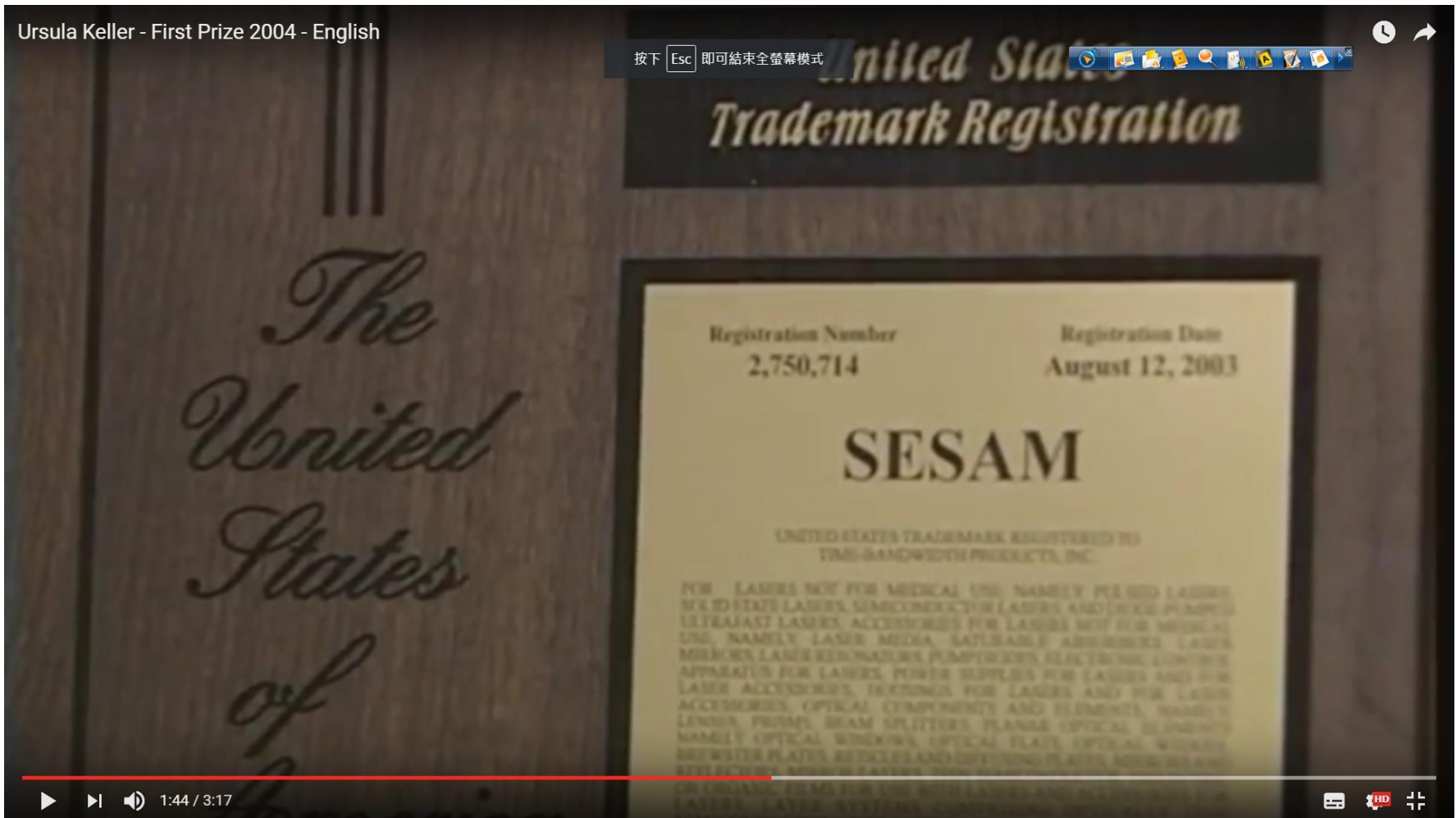
$$\frac{n_1}{n_2} = \sqrt{n_0}$$

so for any glass, we get a range of possible combinations to give an *anti-reflection* coating.

For  $n_0 = 1.51$  then  $\text{MgF}_2$ ,  $n_2 = 1.38$  and  $\text{Al}_2\text{O}_3$ ,  $n_1 = 1.63$  *almost* work!

[illegible]

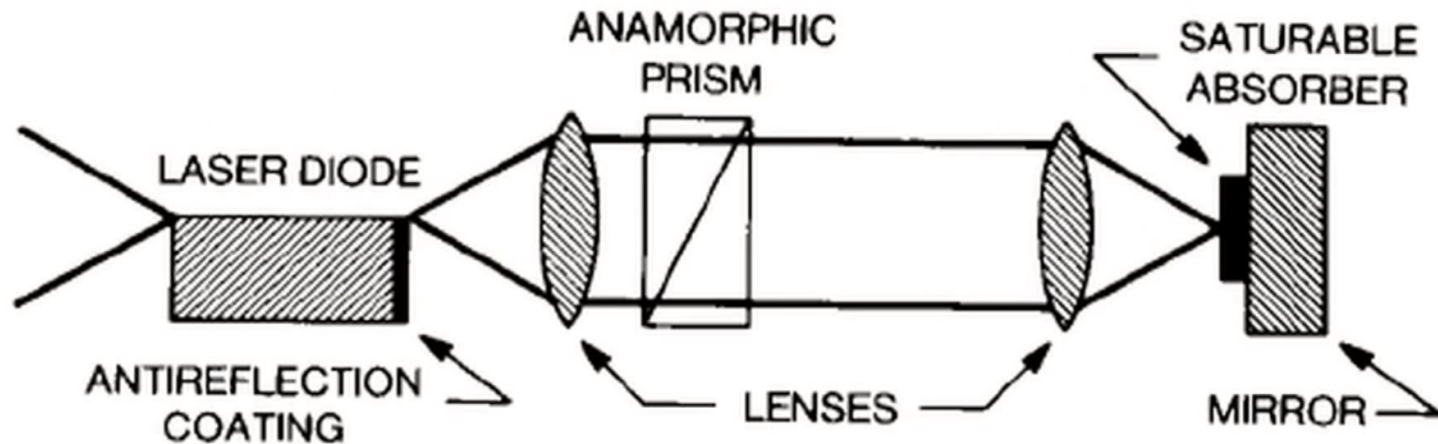
<https://www.youtube.com/watch?v=QbaqNoxPNcQ>



# Mode-locked diode with 20 GHz

➤ <https://www.youtube.com/watch?v=aOTLhk6GuB4>

Modelocked laser diode with 1.6 picosecond pulses at 20 GHz.mp4

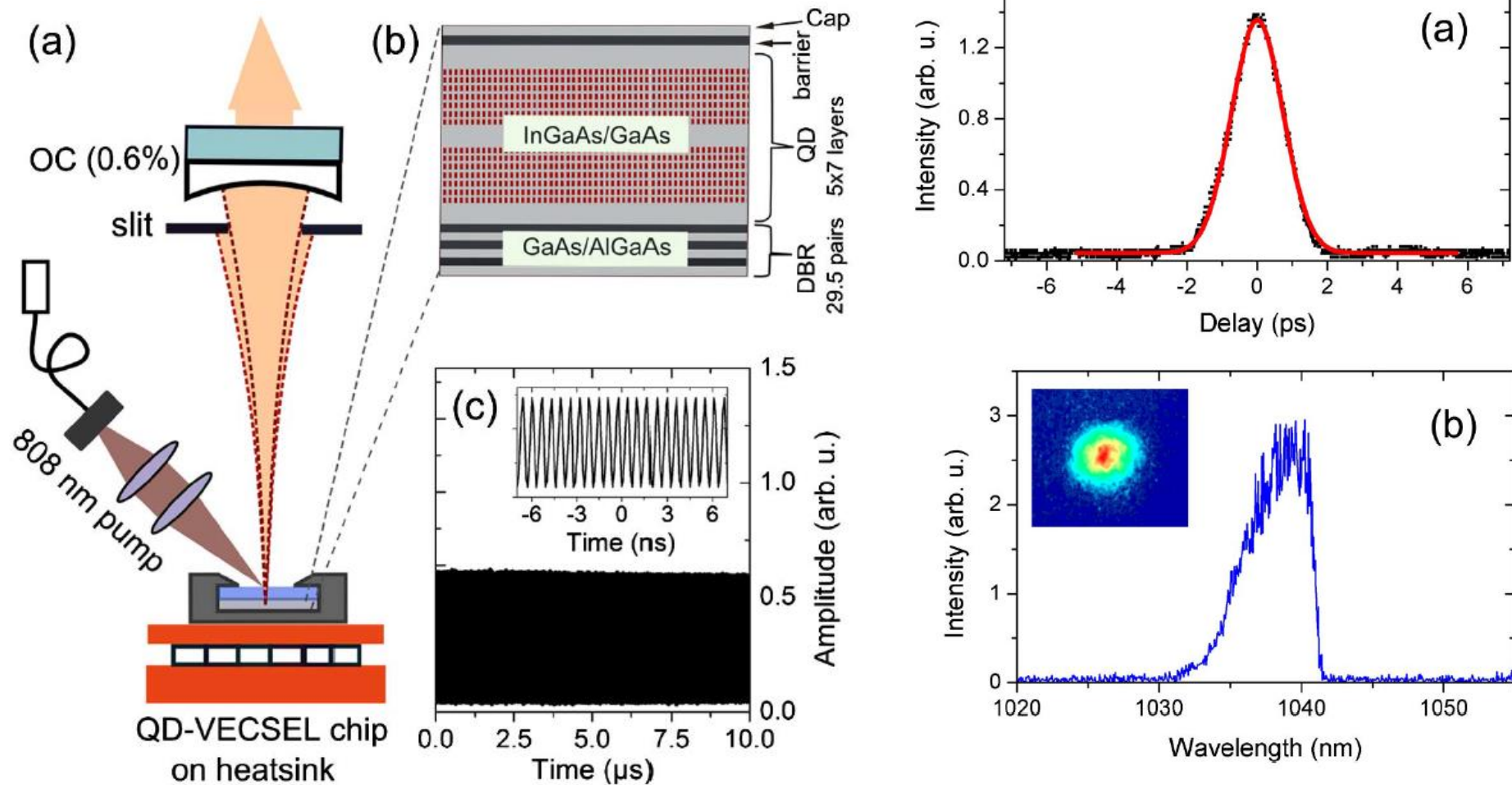


0:06 / 1:24





# Self-mode-locked quantum-dot vertical-external-cavity surface-emitting laser



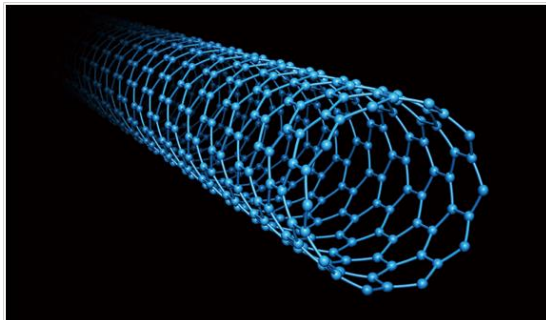


# Passive mode locked fiber lasers in use of saturable absorber

Saturable absorber (SA)	Disadvantage
Carbon nanotubes [1]	1. Working wavelengths related to the diameter of the nanotubes 2. Relatively expensive
Graphene or Graphene oxide [2-3]	1. Small absorption 2. Low modulation depth

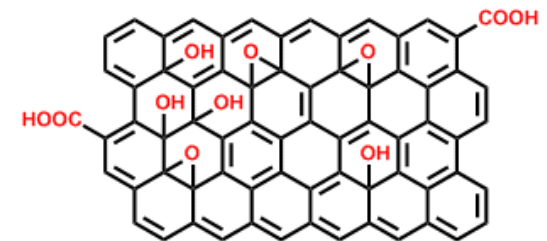
## Molecular structure

### Carbon nanotubes



Graphene

[G0438, G0441, G0442]



Graphene oxide

[G0443, G0444]

[1] F. Wang, et al. Nature nanotechnology 3(12) (2008), 738-742.

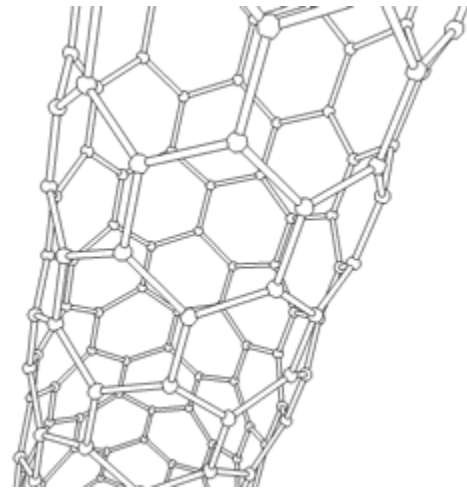
[2] G. Sobon, et al. Laser Physics Letters 9(8) (2012), 581.

[3] J. Lee, et al. Laser Physics Letters 10(3) (2013), 035103.

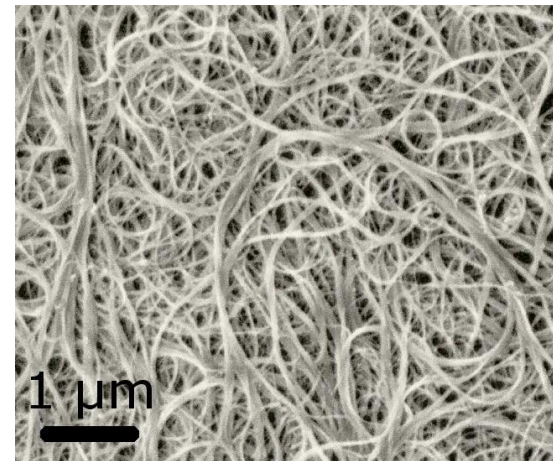
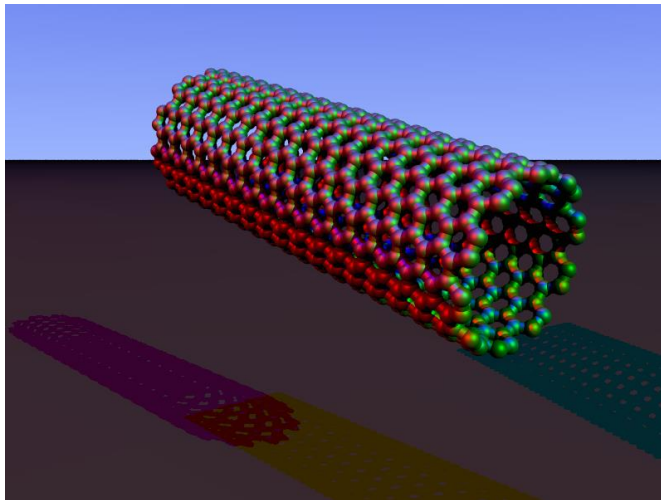
# Carbon nanotubes (CNTs)

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- **Carbon nanotubes (CNTs)** are **allotrope of carbon** with **cylindrical nanostructure**.
- **Nanotubes** have been constructed with **length-to-diameter ratio** of up to 132,000,000:1, significantly larger than for any other material.
- These **cylindrical carbon molecules** have unusual properties, which are valuable for **nanotechnology, electronics, optics** and other fields of **materials science and technology**.
- In particular, owing to their **extraordinary thermal conductivity** and **mechanical and electric properties**, **carbon nanotubes** find applications as additives to various structural materials.
- For instance, nanotubes form a tiny portion of the material(s) in some (primarily **carbon fiber**) **baseball bats, golf clubs**, car parts or **damascus steel**.

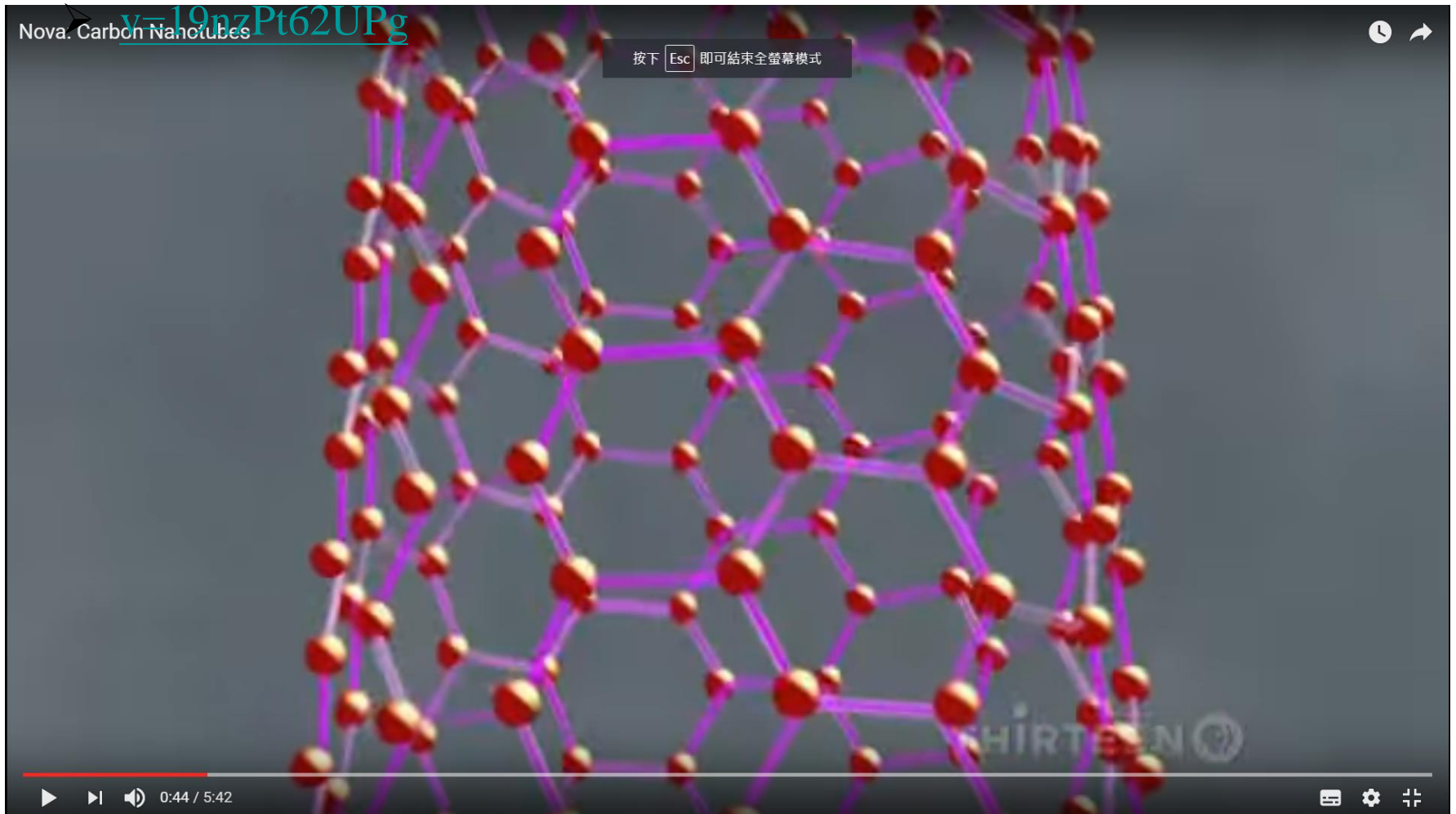


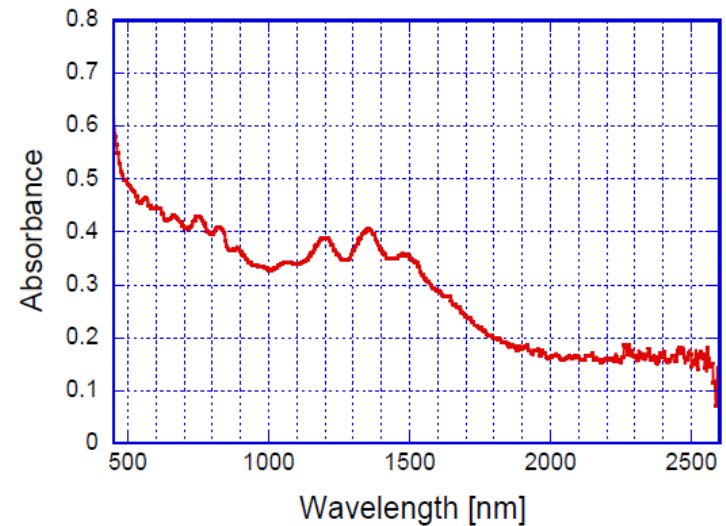
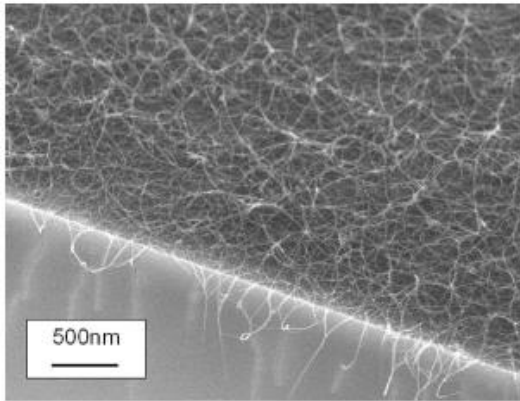
- The name of **nanotubes** is derived from their long, **hollow structure** with the **walls** formed by **one-atom-thick sheets of carbon**, called **graphene**.
- These sheets are rolled at **specific** and **discrete** (“**chiral**”) angles, and the combination of the **rolling angle** and **radius** decides the nanotube properties.
- Nanotubes are categorized as **single-walled nanotubes** (SWNTs) and **multi-walled nanotubes** (MWNTs)



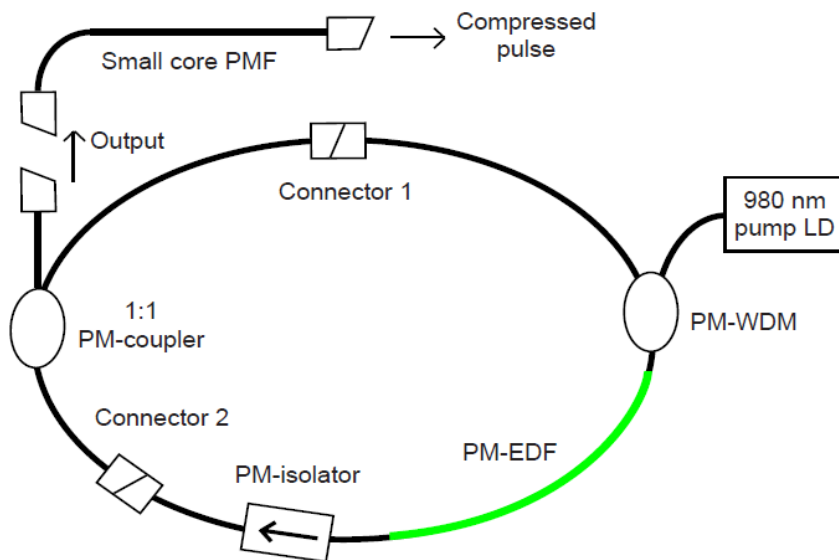
# Carbon nanotube

➤ <https://www.youtube.com/watch?v=19nzPt62UPg>





**SWNT** synthesized directly onto a **quartz substrate**: (a) field-emission scanning electron microscope image, (b) absorption.



Configuration of all polarization-maintaining (PM) passively mode-locked Er-doped ultrashort-pulse fiber laser using **SWNT-polyimide film**.



# Polymer-carbon nanotube films

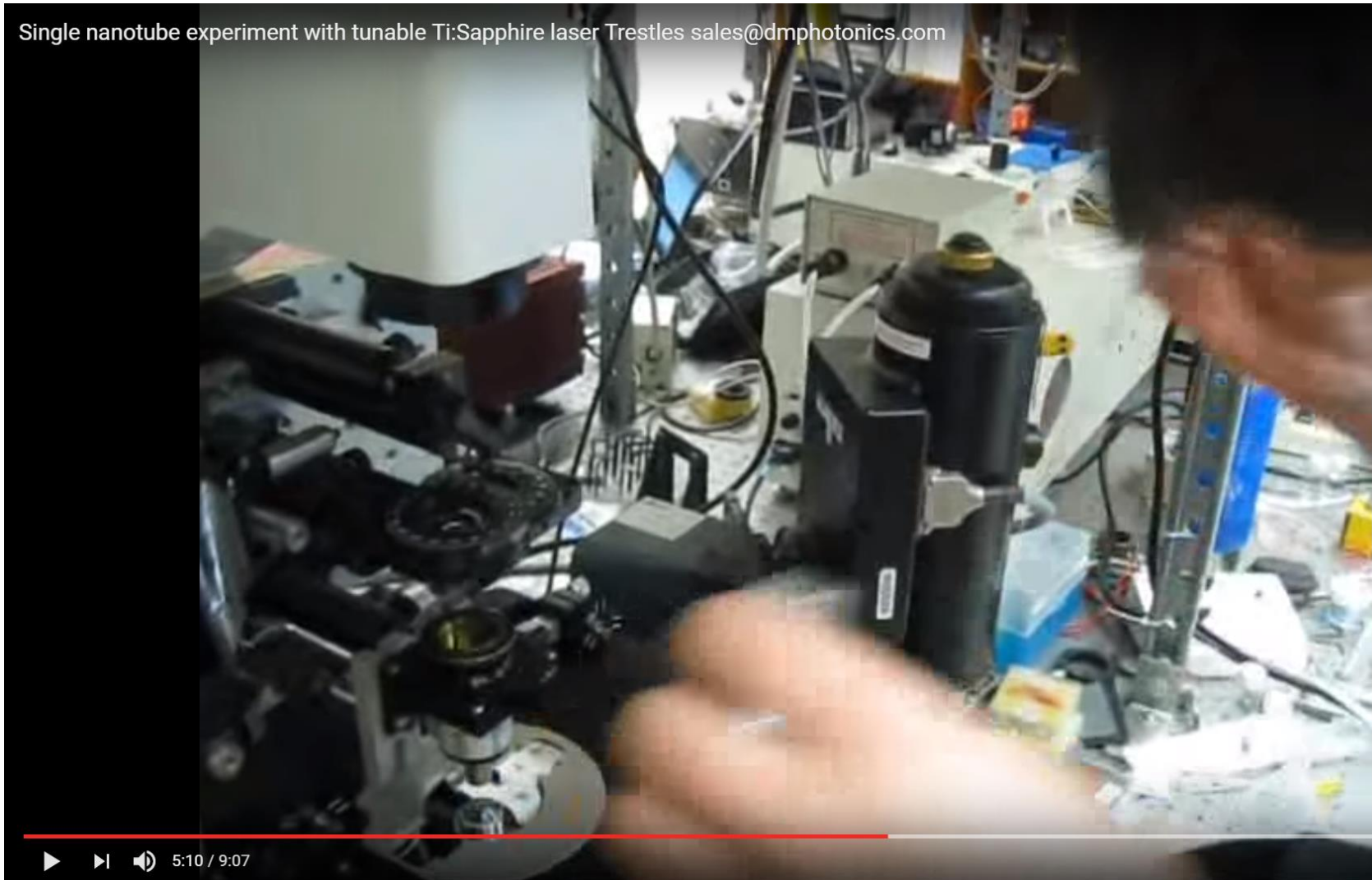
➤ <https://www.youtube.com/watch?v=ATv8lDcwS2s>



# Study carbon nanotube by tunable laser

➤ <https://www.youtube.com/watch?v=1PbWyPjD788>

Single nanotube experiment with tunable Ti:Sapphire laser Trestles sales@dmphotonics.com



# Graphane from wiki

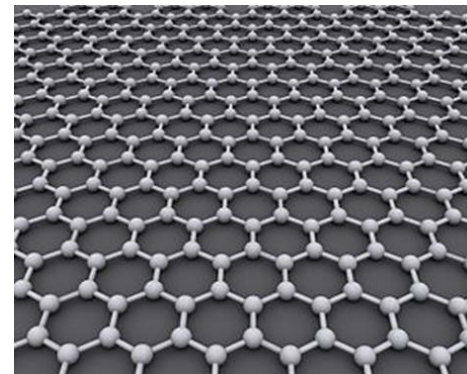
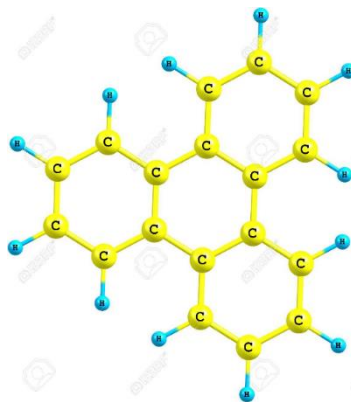
graphit

e



- Graphane is an **allotrope** (同素異形體) of **carbon** in the form of **two dimensional, atomic-scale, honey-comb lattice** in which one atom form each vertex.
- It is the **basic structural element** of other allotrope including

- graphite (石墨)
- charcoal (木炭)
- carbon nanotube
- fullerenes (富勒烯)



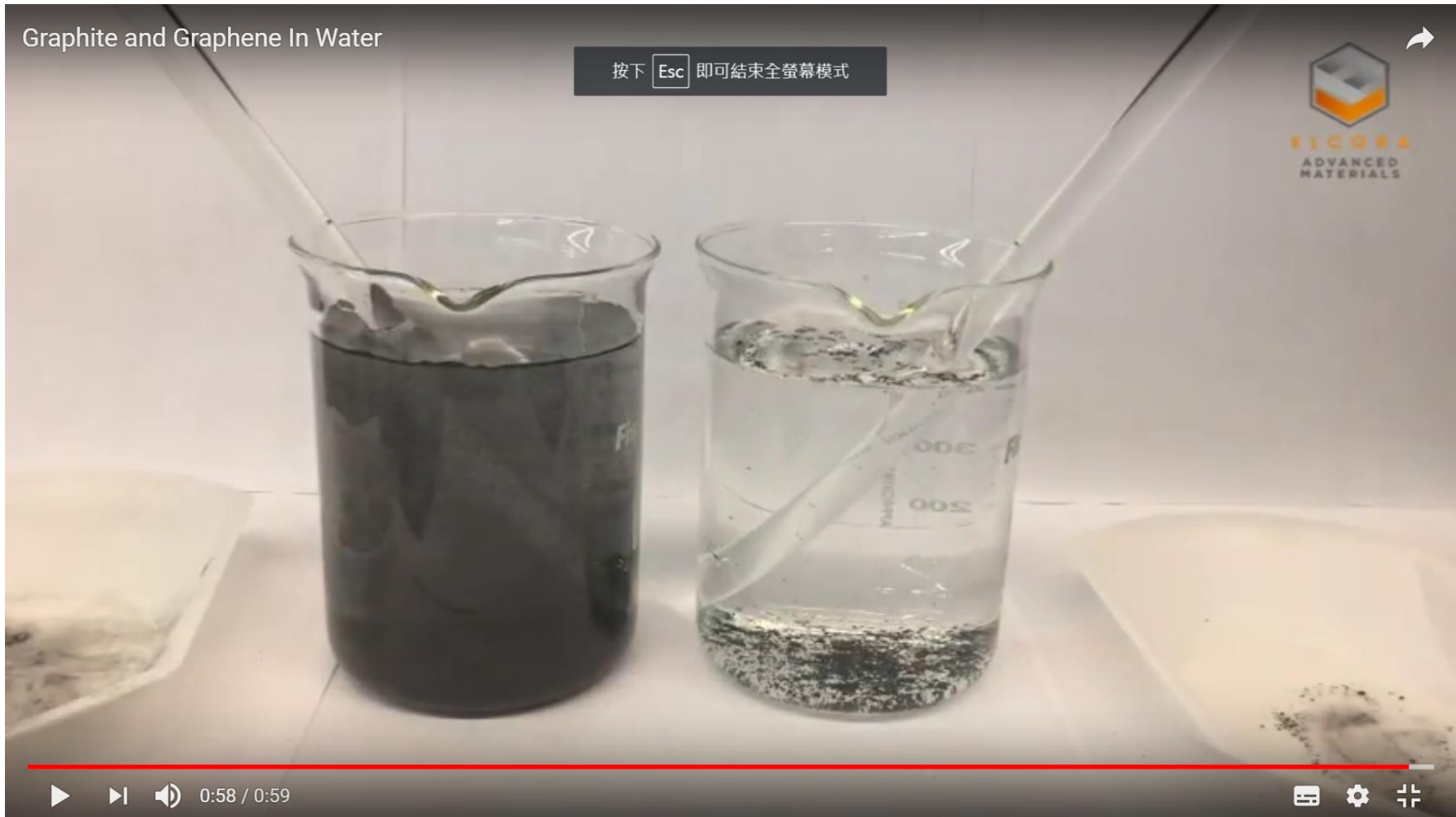
- It can also be considered as indefinitely large **aromatic molecule** (芳香族分子), the ultimate case of the family of **flat polycyclic aromatic hydrocarbons** (聚環狀芳香族碳氫物 or 多環芳香烴).

<https://zh.wikipedia.org/wiki/%E5%A4%9A%E7%92%B0%E8%8A%B3%E9%A6%99%E7%83%B4>



# Graphite and Graphene In Water

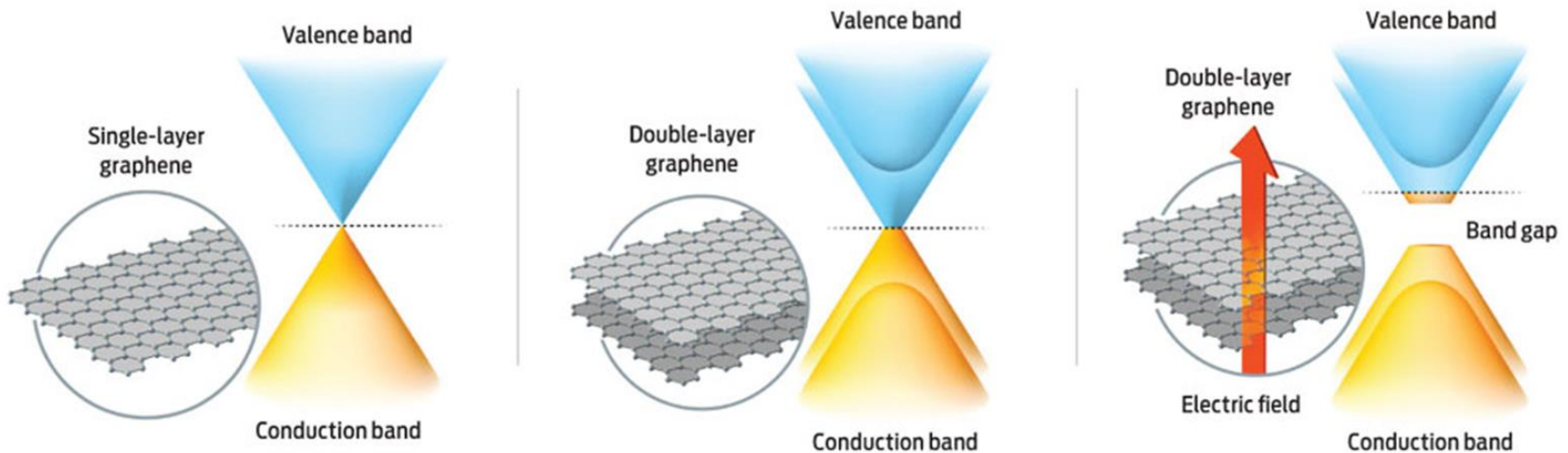
➤ [https://www.youtube.com/watch?v=V\\_aduFC-Ybk](https://www.youtube.com/watch?v=V_aduFC-Ybk)



# Extraordinary properties of Graphene

---

- It is about **100 times stronger** than the **strongest steel**.
- It conducts **heat** and **electricity efficiently** and is nearly **transparent**. [3]
- Researchers have identified the **bipolar transistor effect** (雙極型電晶體), **ballistic transport** (彈道傳輸) of **charges** and **large quantum oscillations** in the material.
- Scientists have theorized about **graphene** for decades.
- It has likely been unknowingly produced in small quantities for centuries, through the use of **pencils** and other similar applications of graphite.
- It was originally observed in **electron microscopes** in 1962, but only studied while supported on **metal surfaces**.



**Breaking Symmetry:** The existence of an energy gap between the **conduction** and **valence electron bands** of a semiconductor is what makes it possible for the material to act as a semiconductor. In both single-layer and double-layer graphene [left and middle], the valence and conduction bands are in effect **conical** and meet at a point, with no band gap.

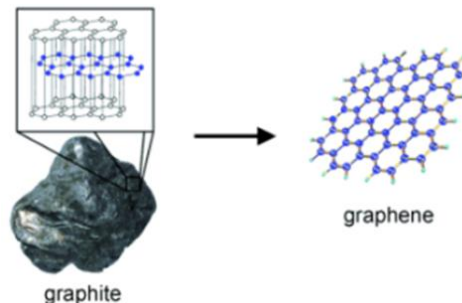
The introduction of an **electric field** perpendicular to the layers [right] creates an asymmetry, which generates a **band gap**. Though small, the gap is tunable, creating possibilities for new devices.

➤ <https://spectrum.ieee.org/semiconductors/materials/graphene-makes-transistors-tunable>

# Novbel Prize of Physics

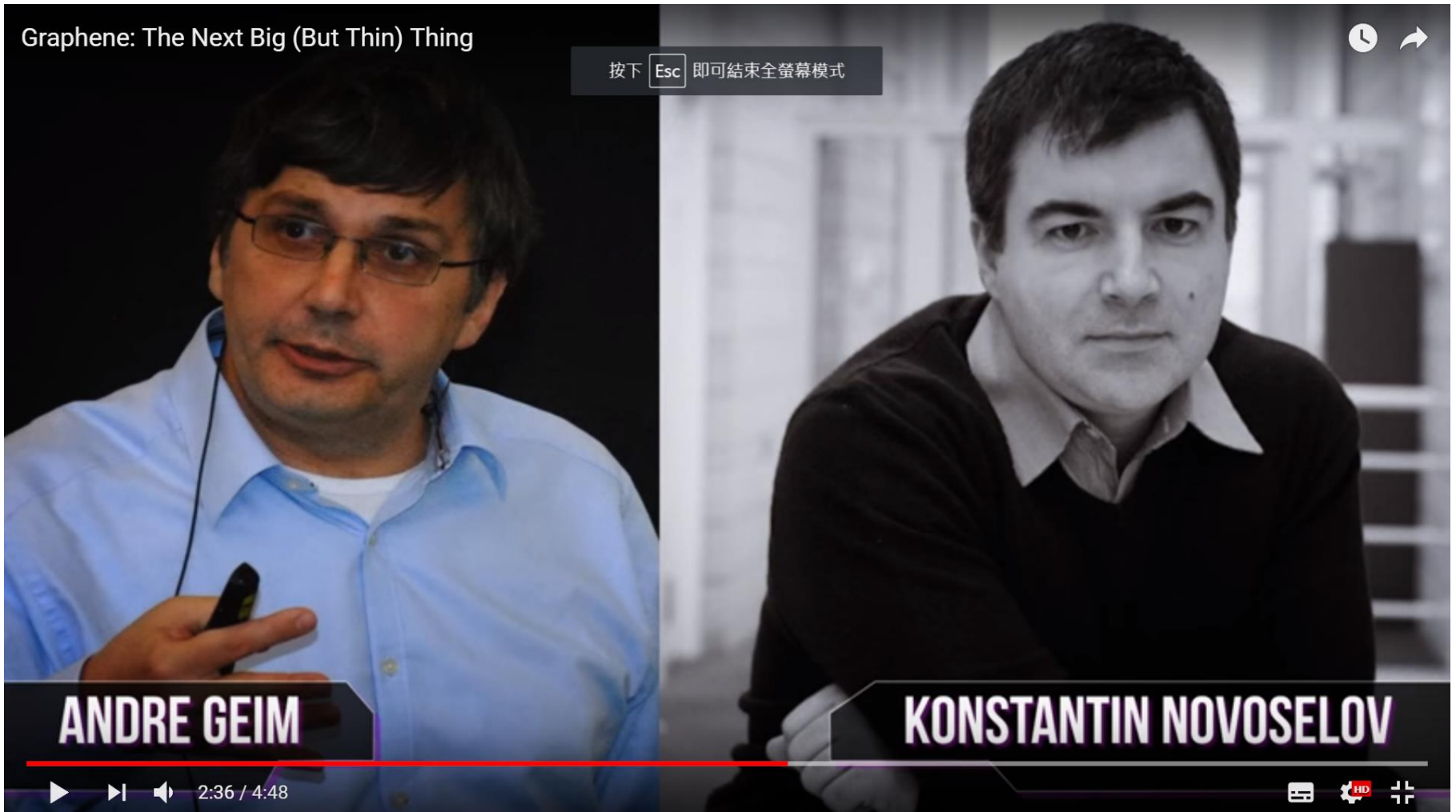
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- The material was later rediscovered, isolated and characterized in 2004 by **Andre Geim** (安德烈·海姆) and **Konstantin Novoselov** (康斯坦丁·諾沃肖洛夫) at the **University of Manchester** (英國曼徹斯特大學).
- Research was informed by existing theoretical descriptions of its **composition, structure and properties**.
- High-quality graphene proved to be surprisingly easy to isolate, making more research possible.
- This work resulted in the two winning the **Nobel Prize in Physics** in 2010 "for groundbreaking experiments regarding the two-dimensional material graphene."



# Graphene: The Next Big (But Thin) Thing

➤ [https://www.youtube.com/watch?v=Mcg9\\_ML2mXY](https://www.youtube.com/watch?v=Mcg9_ML2mXY)

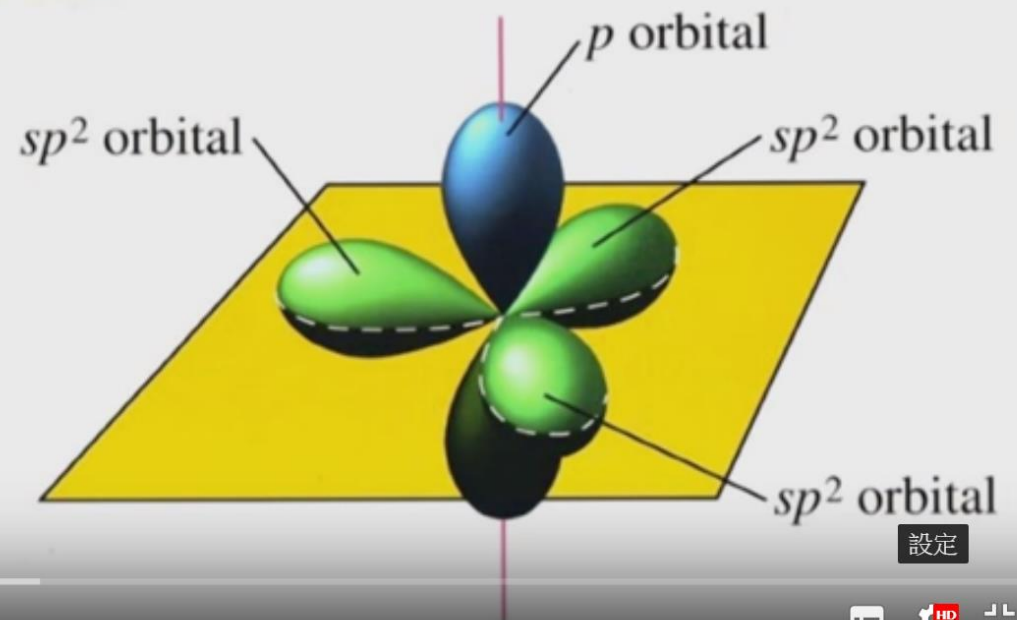
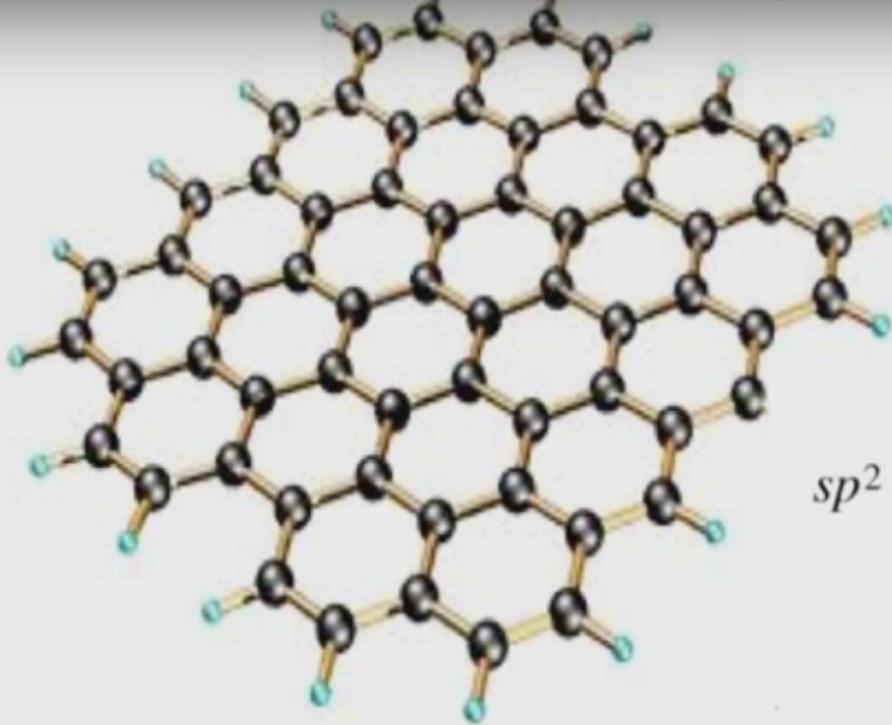




# Graphene science

➤ <https://www.youtube.com/watch?v=eh3dA8xnZ4Y>

Graphene science | Mikael Fogelström | TEDxGöteborg



設定



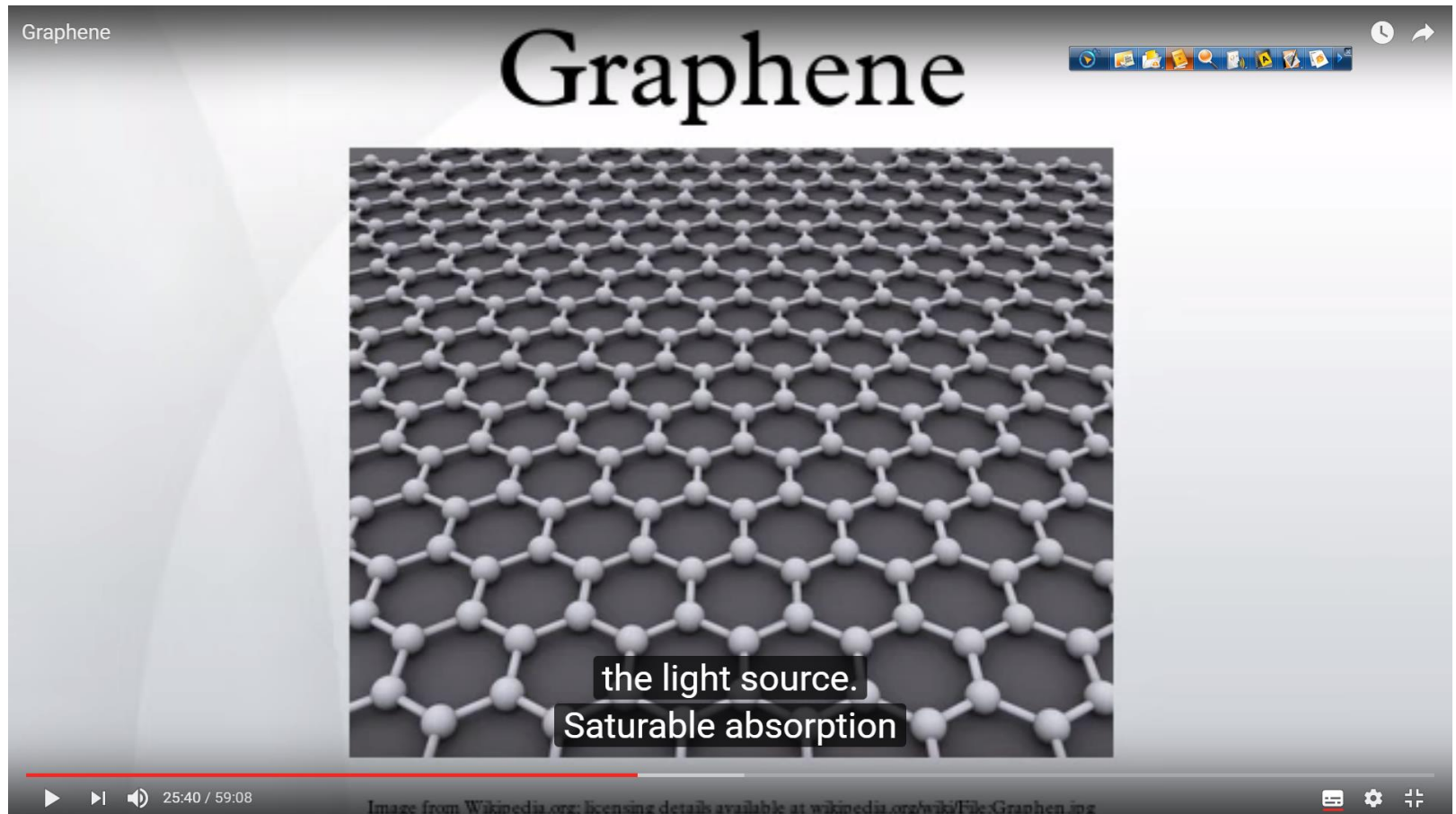
7:00 / 19:58



# Graphene and Graphene oxide (SA 25:40)

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<https://www.youtube.com/watch?v=p5pXzOHhOZE>



# Production of Carbon Nanotubes and Graphene at the MpNL

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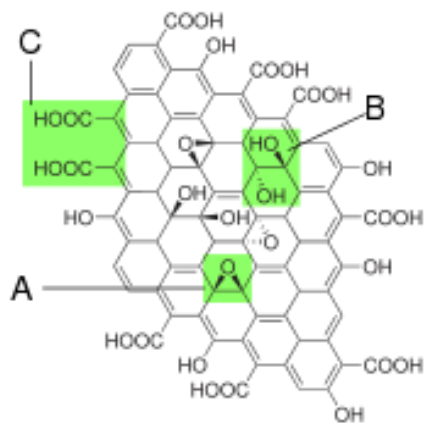
➤ <https://www.youtube.com/watch?v=CuqS8GSpC-4>





# Graphite oxide (from wiki)

- **Graphite oxide**, formerly called graphitic oxide (石墨氧化物) or graphitic acid (石墨酸), is a compound of **carbon**, **oxygen**, and **hydrogen** in variable ratios, obtained by treating graphite with strong oxidizers.
- The **maximally oxidized bulk product** is a **yellow solid** with **C:O ratio** between **2.1 and 2.9**, that retains the layer structure of graphite but with a much larger and irregular spacing

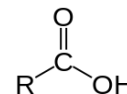


Structure proposed in 1998<sup>[1]</sup> with functional groups.

**A:** Epoxy bridges, (環氧化合物)

**B:** Hydroxyl groups, (羥くーゑ基又稱氫氧基，化學式為-OH)

**C:** Pairwise carboxyl groups. (羧ムメゑ基，通式是R-COOH)



- The **bulk material** disperses in basic solutions to yield **monomolecular sheets**, known as **graphene oxide** by analogy to graphene, the **single-layer** form of graphite.[3]
- Graphene oxide sheets have been used to prepare strong paper-like materials, **membranes**, **thin films**, and **composite materials**.
- Initially **graphene oxide** attracted substantial interest as a possible **intermediate** for the manufacture of **graphene**.
- The graphene obtained by **reduction** of **graphene oxide** still has many chemical and structural defects which is a problem for some applications but an advantage for some others.[4]
- **Graphite oxide** typically preserves the layer structure of the parent **graphite**, but the layers are buckled and the **interlayer spacing** is about **two times larger** ( $\sim 0.7$  nm) than that of graphite.

- Graphite oxide was first prepared by Oxford (牛津大學) chemist Benjamin C. Brodie (班傑明 布羅迪) in 1859, by treating graphite with a mixture of potassium chlorate (氯酸鉀) and fuming nitric acid.<sup>[5]</sup> (濃硝酸)
- He reported synthesis of "paper-like foils" with 0.05 mm thickness.
- In 1957 Hummers (赫爾摩斯) and Offeman (奧佛曼) developed a safer, quicker, and more efficient process called Hummers' method, using a mixture of sulfuric acid  $\text{H}_2\text{SO}_4$  (濃硫酸), sodium nitrate  $\text{NaNO}_3$  (硝酸鈉), and potassium permanganate  $\text{KMnO}_4$ , (高錳酸鉀) which is still widely used, often with some modifications.<sup>[2][6][7]</sup>
- Largest monolayer GO with highly intact carbon framework and minimal residual impurity concentrations can be synthesized in inert containers using highly pure reactants and solvents.<sup>[8]</sup>

# Synthesis of Graphene Oxide GO via Hummer's Method

➤ <https://www.youtube.com/watch?v=RFKBP1pQXes>

Synthesis of Graphene Oxide GO via Hummer's Method - InstaNANO

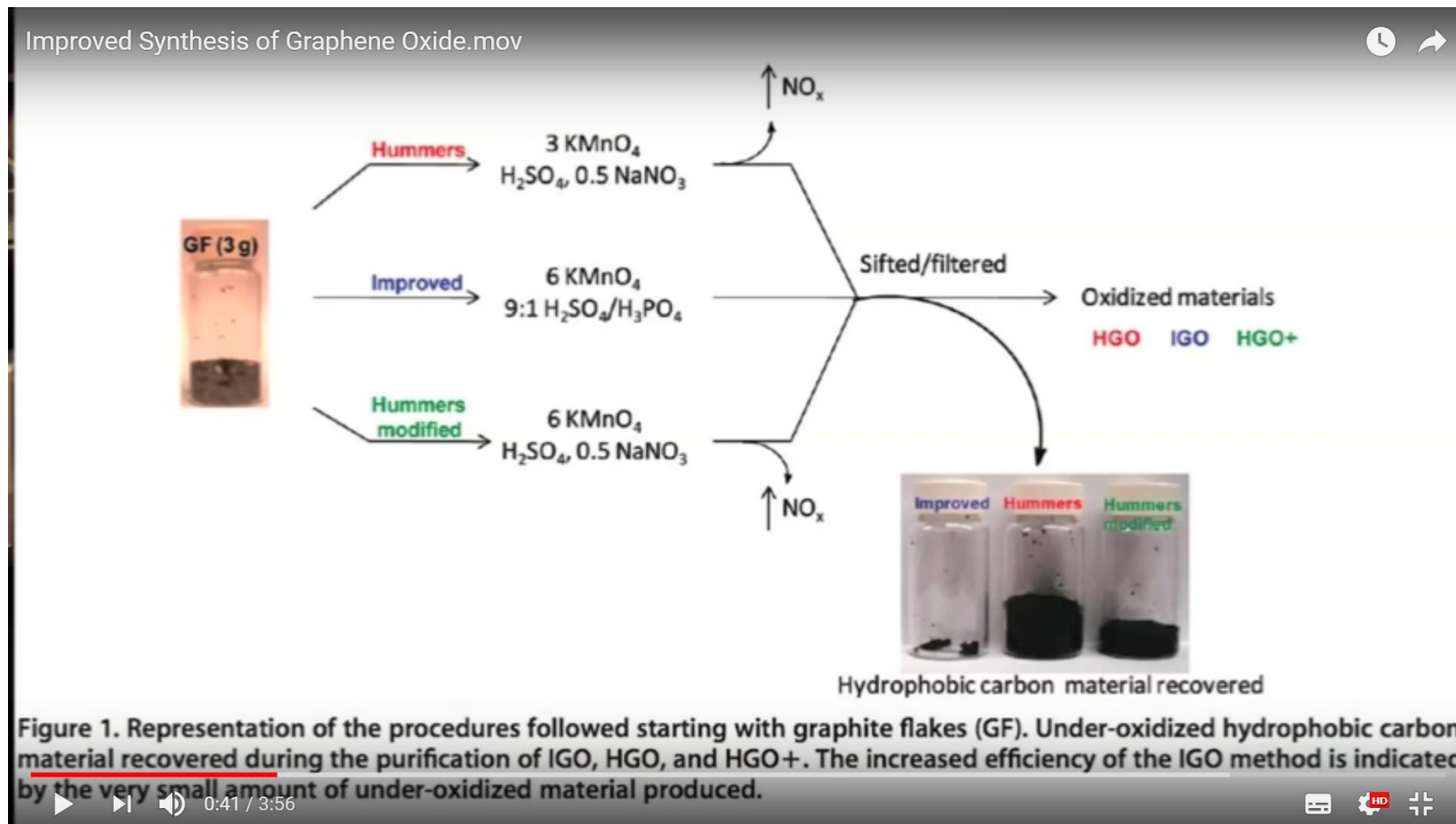


- Take a Beaker & setup ice bath
- Add 25ml Sulphuric Acid
- Add 1g Graphite Powder
- Add 3g Potassium Permanganate slowly
- Add 50ml water drop wise  
**(Very Dangerous)**
- Add 100ml water instantly
- Add 5ml Hydrogen Peroxide



# Improved Synthesis of Graphene Oxide

➤ <https://www.youtube.com/watch?v=sTooYDp1KD4>



# Synthesis of graphene oxide using Modified Hummers Method

➤ <https://www.youtube.com/watch?v=DdPBihCSQ0>

Synthesis of graphene oxide using Modified Hummers Method

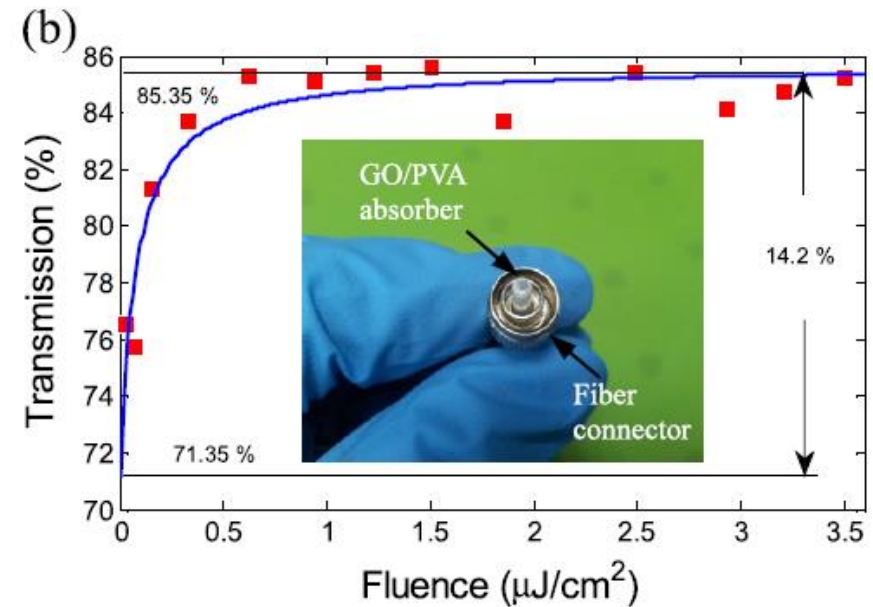
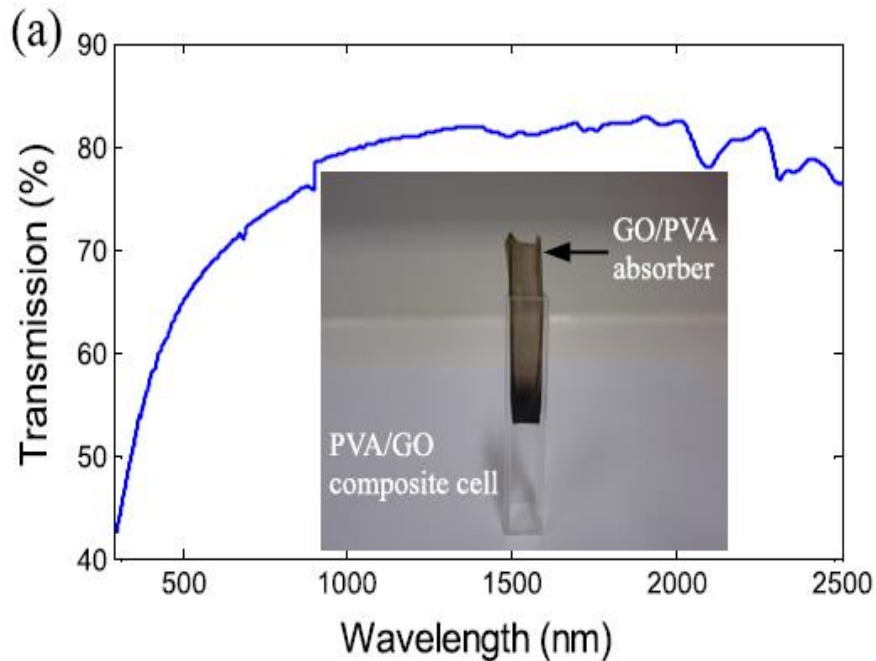


**wash the mixture**  
with 5% HCl and distilled water  
to get PH 7 and filter the graphene oxide solution

▶ ▶▶ 🔊 1:25 / 1:32

⚙️ HD 🔍

# All-normal-dispersion passively mode-locked Yb-doped fiber ring laser based on a graphene oxide saturable absorber

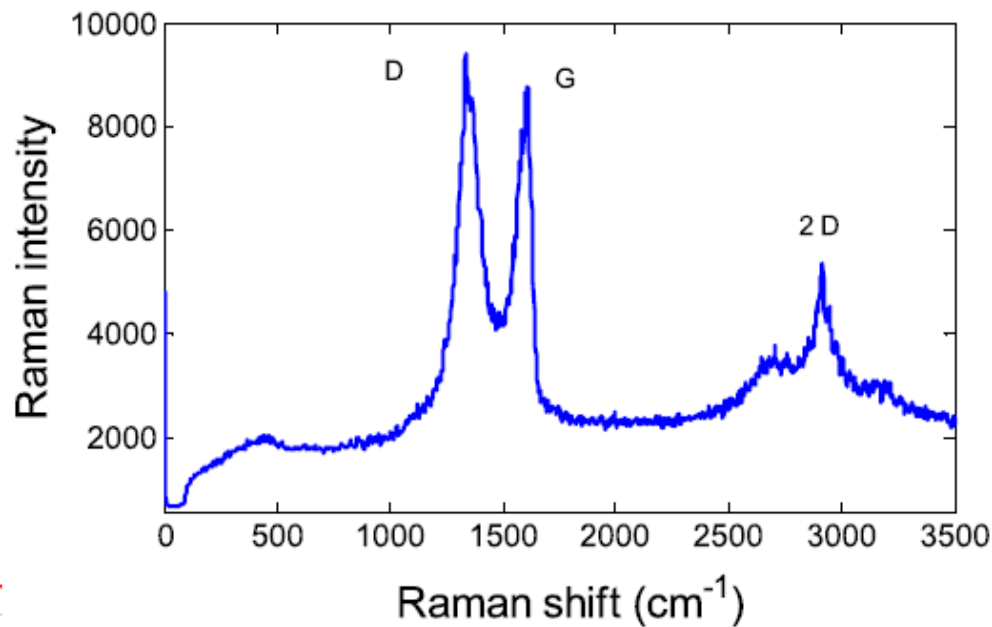


- (a) Linear transmission curve of the fabricated GO–PVA absorber.
- (b) Measured transmission curve with an increase of the probe laser power in the 1  $\mu\text{m}$  regime.

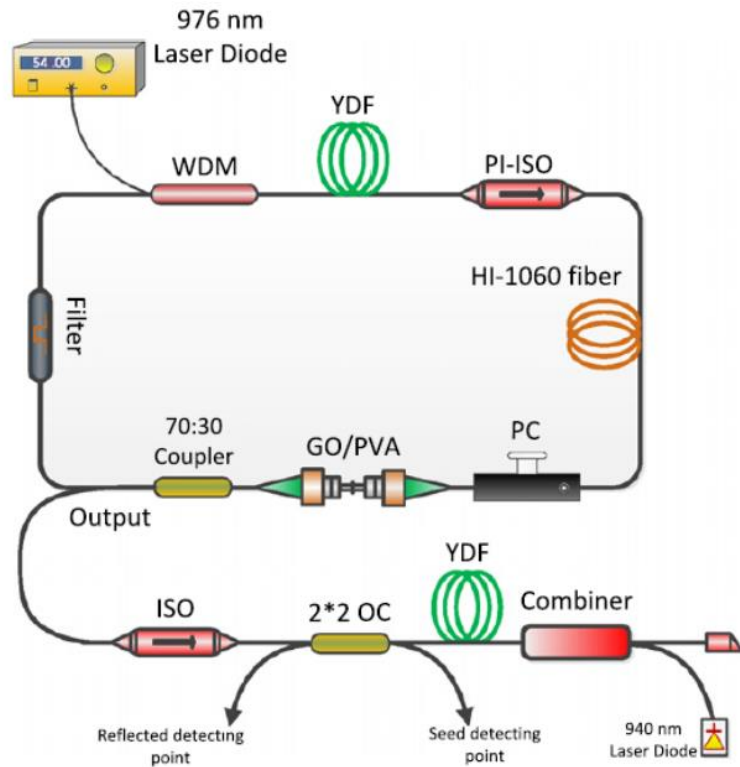


- The D peak is due to the **defect-induced breathing mode** of  $sp^2$  rings. It is from the **structural imperfections** created by the attachment of **hydroxyl** (氫氧根) and **epoxide** (環氧化物) groups on the carbon basal plane.
- The G peak corresponds to **optical photons  $E_{2g}$**  at the **Brillouin zone center** and is due to **bond stretching** of  $sp^2$  carbon pairs in both rings and chains.
- The **2D band** represents the existence of **graphene material**

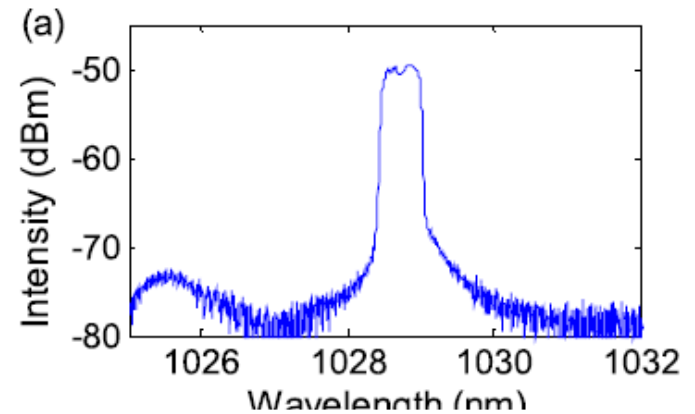
## Raman spectrum of Graphene oxide



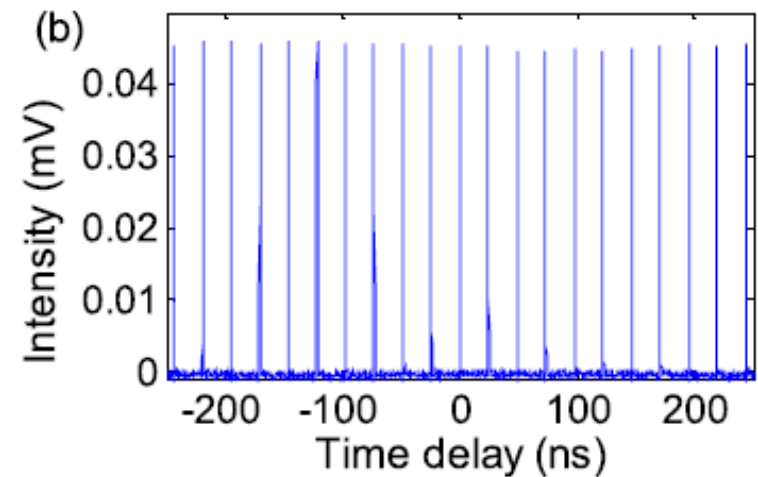
# Experimental Setup



## Optical spectrum



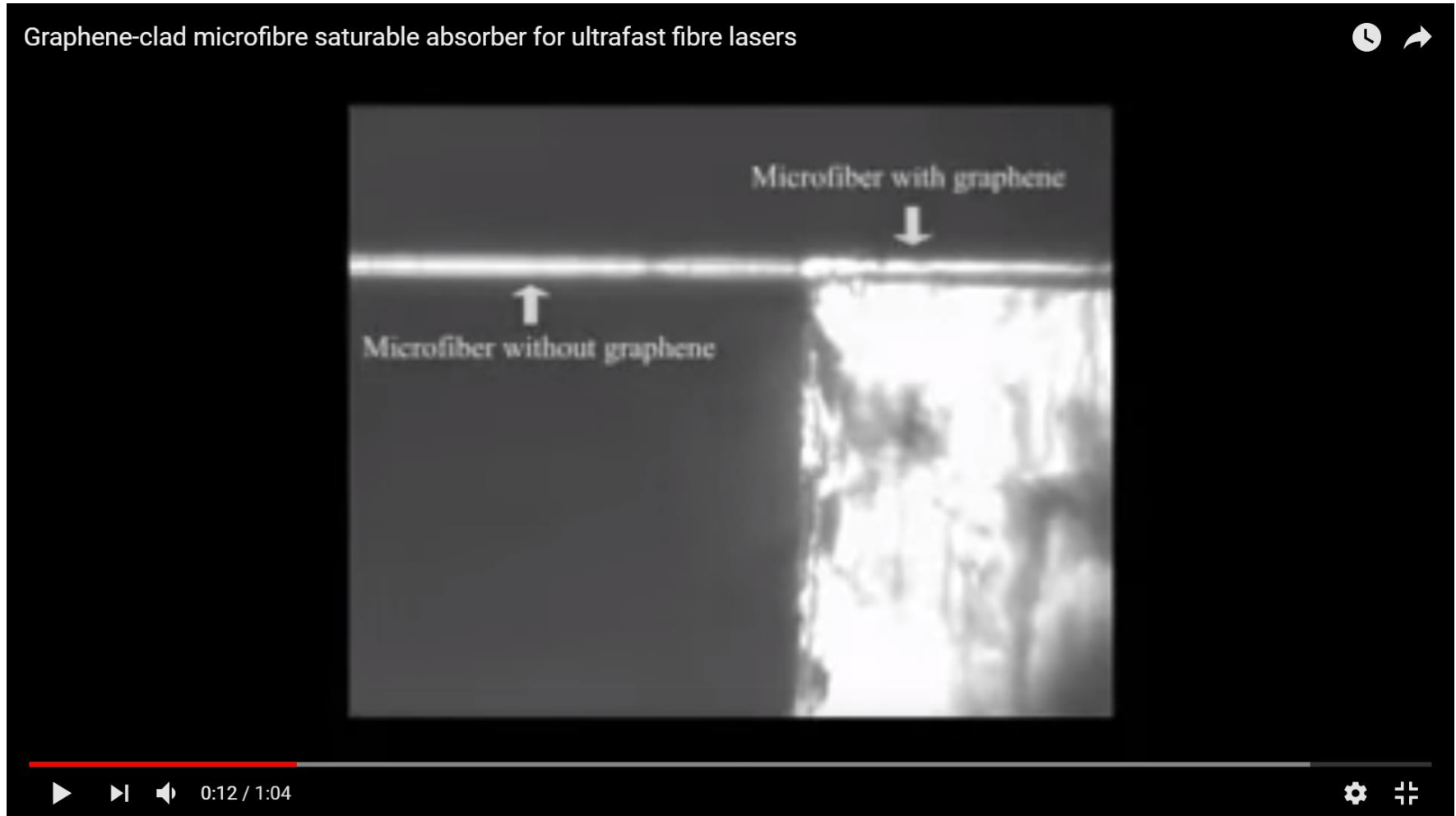
## Time Trace from OS



Laser Phys. Lett. 10 (2013) 075108 (5pp)

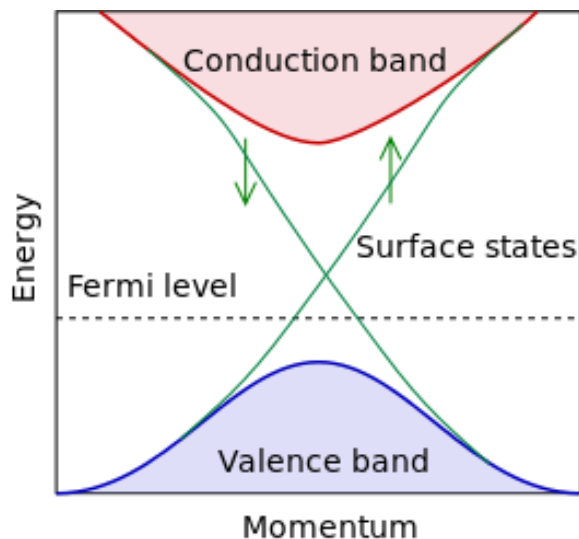
# Graphene-clad microfibre saturable absorber for ultrafast fibre lasers

➤ <https://www.youtube.com/watch?v=dIoeqQAyrHY>



# Topological insulators

- **Topological insulators** such as  $\text{Bi}_2\text{Se}_3$ ,  $\text{Bi}_2\text{Te}_3$  and  $\text{Sb}_2\text{Te}_3$  have attracted much attention for their promising applications in fiber lasers .
- Topological insulator is a **novel** kind of **quantum electronic matter** which behaves **metallic states** in **surface** but **insulator states** in interior, meaning that electrons can only move along the surface of material.



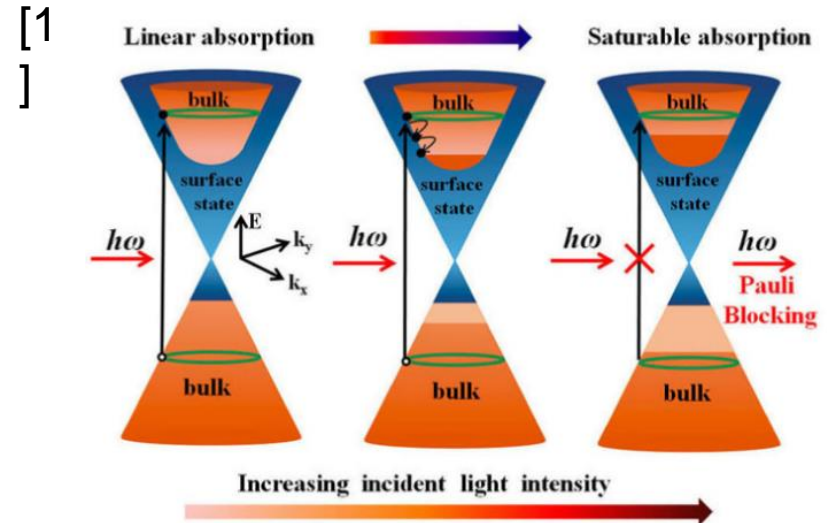
In the bulk of a non-interacting topological insulator, the electron band structure resembles an ordinary **band insulator**, with the **Fermi level** falling between the conduction and valence bands.

On the **surface** of a topological insulator there are special states that fall within the **bulk energy gap** and allow surface

# Introduction of Topological insulator

## Characteristic of TI

1. Dirac-like electronic band structure
2. Widely studied in the condensed-matter physics
3. Wavelength independent, low saturable optical intensity, high damage threshold, large modulation depth,
4. The used TI in PM-FLs
  1.  $\text{Bi}_2\text{Te}_3$
  2.  $\text{Bi}_2\text{Se}_3$
  3.  $\text{Sb}_2\text{Te}_3$
  4. ....



➤  $\text{Bi}_2\text{Se}_3$  has a relatively larger bulk band gap (0.3 eV), and it is considered as a promising optical material for the room-temperature applications

# Preparation of $\text{Ti}:\text{Bi}_2\text{Se}_3$ nanoplates

## Polyol method

two-neck  
flask



$\text{Bi}(\text{NO}_3)_3 \cdot 5\text{H}_2\text{O}$  0.6 g  
sodium selenite 0.3 g  
polyvinyl pyrrolidone 1.32 g  
ethylene glycol 60 mL

Heating and stirring  
At 190 °C for 3 ~ 6 hr

Centrifugation Clearing  
6000 RPM 10min

Drying  
Put in Oven 50 °C 4 hrs

Powder



Microbalancer



Three reagent and ethylene glycol (EG) is solvent

# Preparation of $\text{Bi}_2\text{Se}_3$ PVA/film

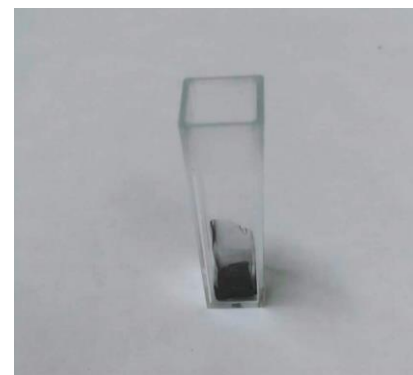


← Ultrasonication agitation  
4.5 hr

↓ Adding PVA  
( 0.02 g/ml)

← Heating and stirring  
At 90 °C for 3 ~ 4 hr

↓ Drying  
3 Days





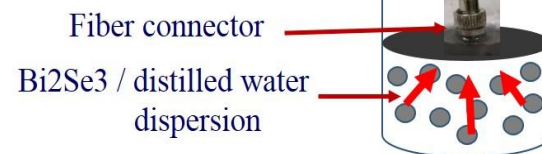
# End facet deposition of $\text{Bi}_2\text{Se}_3$



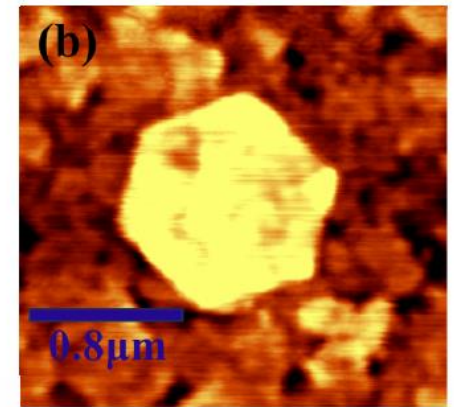
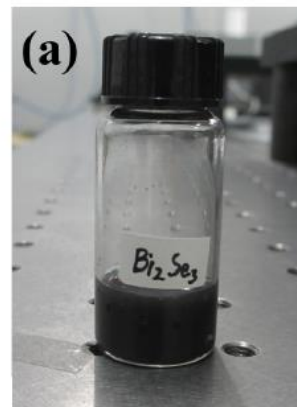
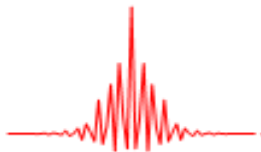
← Ultrasonication agitation  
3 hr

↓ Illumination  
976 nm, 40 mW for 3 hr

↓ Drying  
50° C for 3 hr  
←

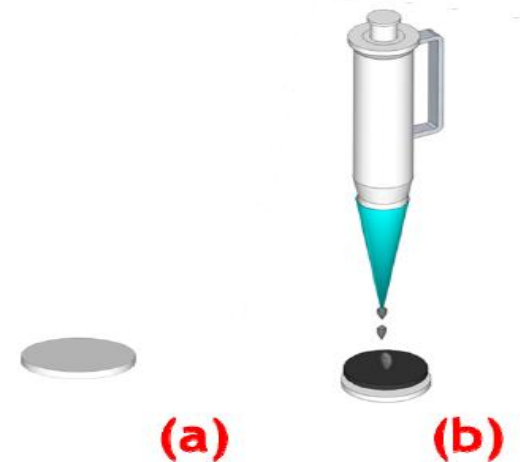


- In order to remove the impurity, the  $\text{Bi}_2\text{Se}_3$  solution was washed with **isopropyl alcohol (IPA 異丙醇)** and centrifuged several times.
- Dispersion suspensions of  $\text{Bi}_2\text{Se}_3$  in **deionized water solution (DI water)** were prepared by **centrifugation** and **ultrasonication agitation** for 1 hour, as shown in Fig.1(a).
- The  $\text{Bi}_2\text{Se}_3$  solution was observed by **atomic force microscope (AFM)**, as shown in Fig.1(b).
- The thickness of the TI:  $\text{Bi}_2\text{Se}_3$  NPs was about 10-15 nm.
- The thickness of the **single layer**  $\text{Bi}_2\text{Se}_3$  was **0.96 nm**, so the TI:  $\text{Bi}_2\text{Se}_3$  we obtained were estimated to be 10-16 layers.

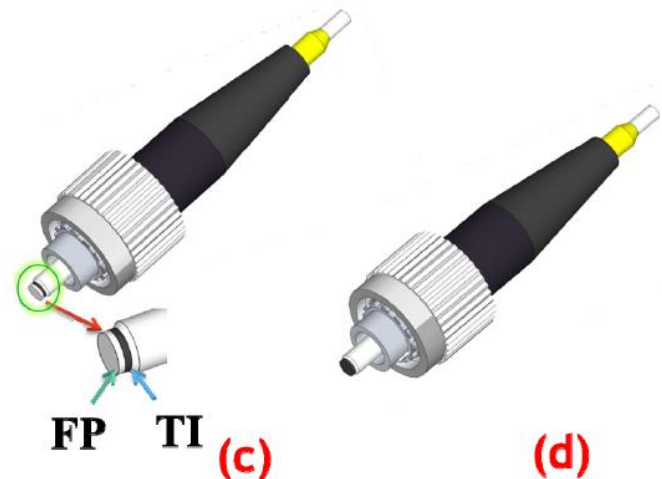


# The procedures of the preparation of pure $\text{Bi}_2\text{Se}_3$ -SA (BS-SA) film.

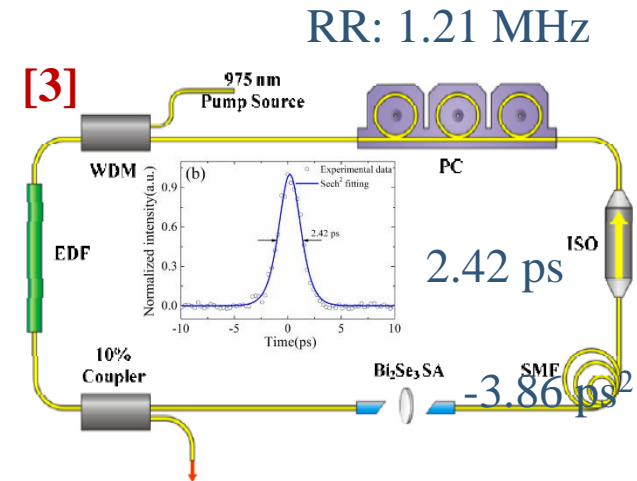
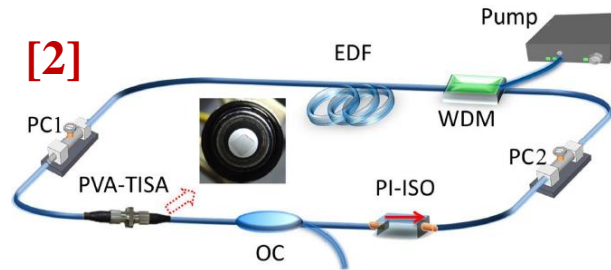
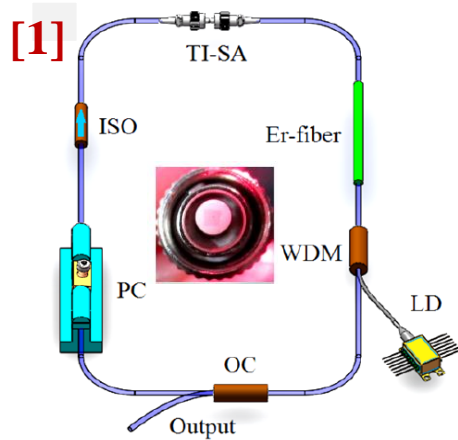
- Firstly, **filter paper (FP)** (GVWP02500 Millipore) with the pore size of  $0.22\ \mu\text{m}$  was immersed in **deionized water** until it **soaked** completely, as shown in Fig. (a).
- Then  **$\text{Bi}_2\text{Se}_3$  water solution** was drop wise added on the filter paper slowly, as displayed in Fig. (b).
- The pure  $\text{Bi}_2\text{Se}_3$  remained on the surface of filter paper due to the diameter of  $\text{Bi}_2\text{Se}_3$  morphologies ( $1.2\ \mu\text{m}$ ) was larger than the **pore size** of the filter paper.



- Put the filter paper with  $\text{Bi}_2\text{Se}_3$  in drying oven until filter paper dried thoroughly, as displayed in Fig. 1(c).
- Thirdly, shear a small piece from the prepared  $\text{Bi}_2\text{Se}_3$  filter paper and put it on the face of a fiber end-facet, as shown in Fig.(c).
- At last, put the **fiber end-facet** with the  $\text{Bi}_2\text{Se}_3$  filter paper into **acetone solution** (丙酮) to remove the filter paper (Fig. 2(d)).
- The filter paper needed washing quite a few times.

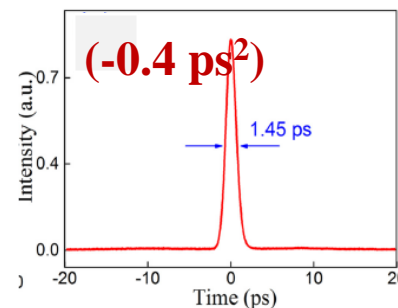
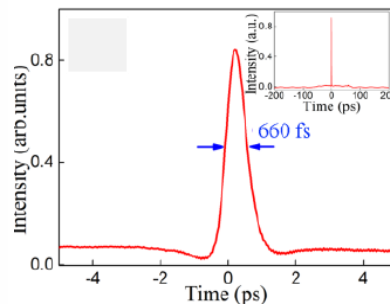
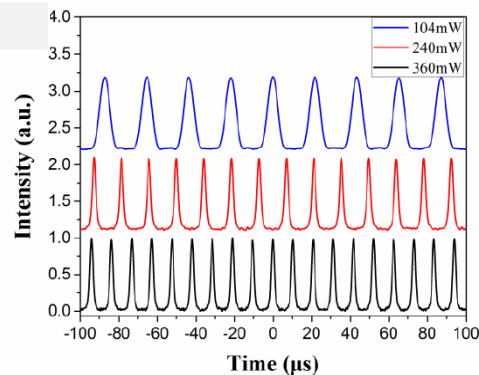


# PML or Q-switched pulse generation in EDFL by using $\text{Bi}_2\text{Se}_3$ as a SA

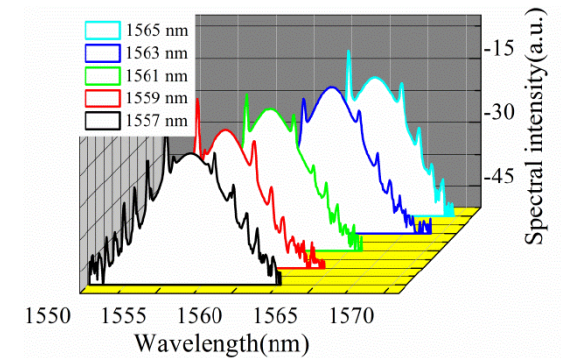


The influence of cavity dispersion on the pulse duration

Q-switched fiber laser

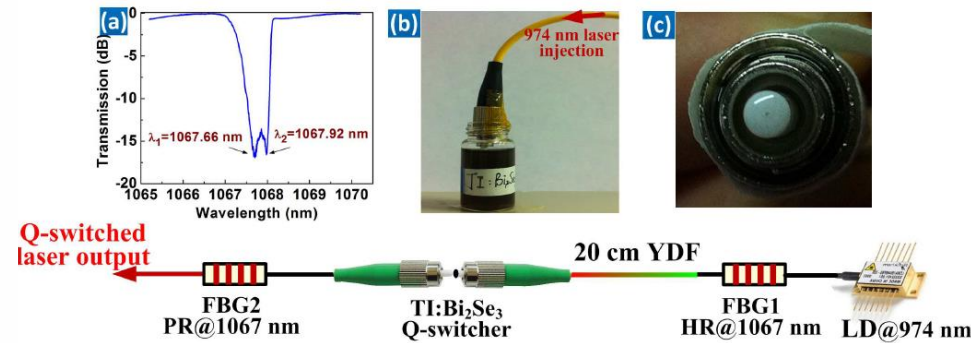
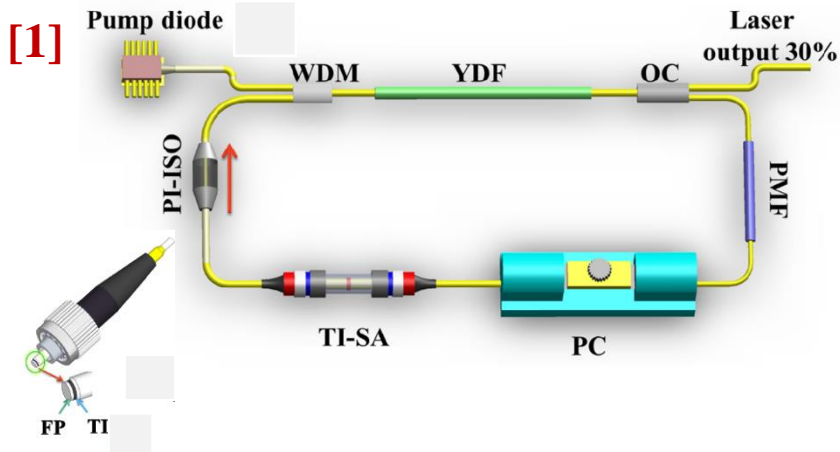


Wavelength tunable PML EDFL

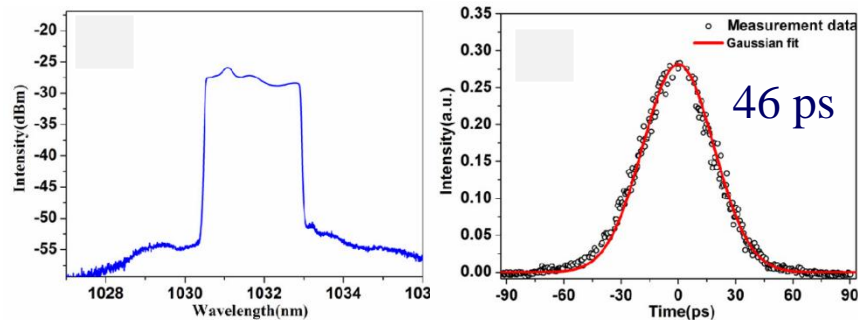


# PML or Q-switched pulse generation in YDFL by using $\text{Bi}_2\text{Se}_3$ as a SA

[2]



Mode-locked fiber laser with PMF



Q-switched fiber

RR: 19.5 kHz

